

CHAPTER IV

RESULTS AND DISCUSSIONS

4.1 Role of chitosan content on TiO₂/chitosan and chitosan films preparation.

In this experiment, TiO₂/chitosan film prepared by mixing TiO₂ (Degussa P-25) with chitosan flake from crab shells which was highly viscosity in acetic acid solution. The physical and chemical properties of chitosan flake present in table 4.1. For TiO₂ powder (Degussa P-25) and chitosan flake that used in this research were shown in figure 4.1.

Table 4.1 Physical and chemical properties of chitosan flake(Fluka, Sigma-aldrich co., plc.)

Physical and chemical properties	Values
Moisture content (%)	6
Sulfated ash(%)	0.3
Viscosity(mPas)	411*
Deacetylation (%)	85-90
Molecular weigh(gram/mole)	~600,000

* 1% chitosan in 1% acetic acid at 20 C^o

TiO₂/chitosan films in different conditions were prepared by dissolving 1, 1.5, 2 and 2.5% w/w of chitosan flake with 0.4% Ti from TiO₂ powder in 20% acetic acid solution for 24 hr So TiO₂/chitosan slurry which were similar to glue. After that 5 g of slurry were taken and spread them on 5x6 cm glass plate then placed its in room temperature to dry for 48 hr Next step, the film was peeled out from glass plate. And stored in the confined space.

For chitosan films were prepared by dissolving 1, 1.5, 2 and 2.5% w/w of chitosan flake in 20% acetic acid solution without TiO₂ power in same method of TiO₂/chitosan films preparation.

4.1.1 Results of film weight, thickness and characteristic

Effect of varying chitosan content on properties of film show in table 4.2 – 4.4 so, chitosan content was important factor that influence on chitosan and TiO₂/chitosan films properties such as weight, thickness and characteristics of film. Weight of film results represent in table 4.2. In this study, the weight of TiO₂/chitosan film was obtained in ranged of 0.0896-0.1649 g ± 0.029 whereas the weight of chitosan film was in ranged of 0.0534-0.1295 g. ± 0.030 This result could be compared between TiO₂/chitosan and chitosan film weight and it was found that the weight of TiO₂/chitosan film was heavier than weight of chitosan film because of the addition of 0.4% Ti on TiO₂/chitosan film. When consideration about the relation between the films which prepared in difference of chitosan contents, the result shown that trend of film weight of all samples were increased if increased chitosan content and weight of film that prepared from 1% chitosan was the lightest weight.

Regarding film thickness (Table 4.3), the thickness of TiO₂/chitosan film was obtained in ranged of 0.027-0.056 mm ± 0.013 while the thickness of chitosan film was in ranged of 0.014-0.041 mm ± 0.011. When compared between chitosan content on films in different chitosan contents were found that the thickness of film that prepared from 1% chitosan was the thinnest of film and the trend thickness of all films were increased with increasing chitosan content.

From this result, it could be concluded that the relation between chitosan content with weight and thickness of film, its weight and thickness tended to increase with the increasing of chitosan content. These results were similar to Sukkunta's research (2002).

The properties of prepared TiO₂/chitosan and chitosan films such as coarseness, transparent and acid odor of film were observed. The physical properties

of film show in table 4.4. The film surface that exposed to the air was coarse, while the reverse surface touching glass was smooth and there were no acid odor after dry in room temperature for 48 hr. These results were similar to Sukkunta's research, 2002 which reported that drying of film could reduce the acidic odor and the transparent of film was observed. Chitosan films were transparent film which look like clear plastic on the other hand TiO_2 /chitosan films look like dense plastic. Pictures of TiO_2 /chitosan and chitosan films show in figure 4.2.

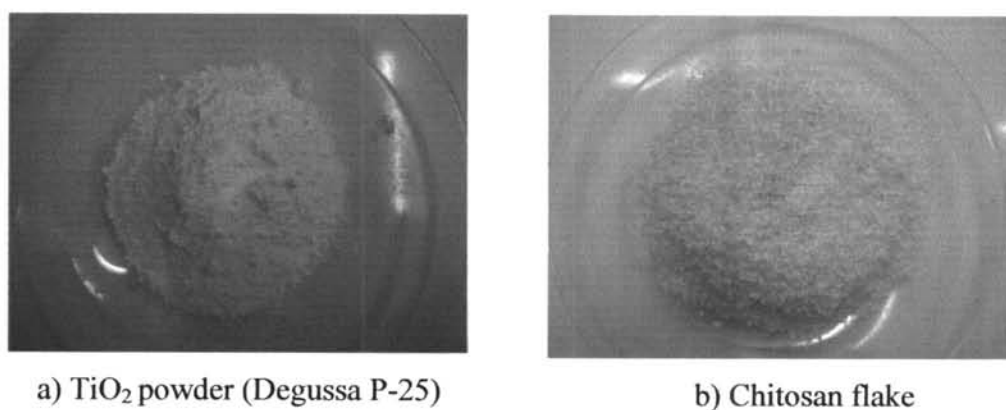


Figure 4.1 TiO_2 powder (Degussa P-25) and chitosan flake that used in this research

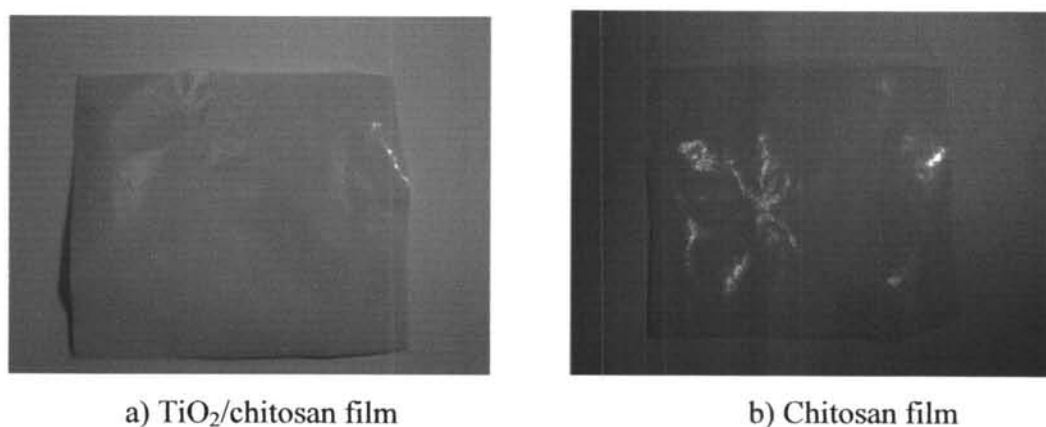


Figure 4.2 Formation of TiO_2 /chitosan and chitosan films

Table 4.2 Weight of film that prepared from 1, 1.5, 2 and 2.5% chitosan with 0.4% Ti (TiO₂/chitosan film) and without Ti content(chitosan film)

Types of film	Chitosan contents (%)	Ti contents (%)	Weight of film (g)					Average (g)	SD
TiO ₂ /chitosan film	1	0.4	0.0843	0.0955	0.0871	0.0901	0.0911	0.0896	0.0042
	1.5	0.4	0.1181	0.1134	0.1145	0.1132	0.1114	0.1141	0.0025
	2	0.4	0.1394	0.1413	0.1393	0.1419	0.1431	0.1410	0.0016
	2.5	0.4	0.1611	0.1639	0.1623	0.1681	0.1696	0.1649	0.0035
Chitosan film	1	0	0.0583	0.0514	0.0520	0.0542	0.0512	0.0534	0.0030
	1.5	0	0.0781	0.0811	0.0801	0.0800	0.0810	0.0801	0.0012
	2	0	0.1053	0.1060	0.1201	0.1113	0.1168	0.1119	0.0045
	2.5	0	0.1324	0.1371	0.1251	0.1282	0.1245	0.1295	0.0043

Table 4.3 Thickness of film that prepared from 1, 1.5, 2 and 2.5% chitosan with 0.4% Ti (TiO₂/chitosan film) and without Ti content(chitosan film)

Type of film	Chitosan contents (%)	Ti contents (%)	Thickness of film (mm)					Average (mm)	SD
TiO ₂ /chitosan film	1	0.4	0.030	0.035	0.027	0.025	0.020	0.027	0.006
	1.5	0.4	0.043	0.035	0.035	0.030	0.045	0.038	0.006
	2	0.4	0.050	0.040	0.045	0.050	0.050	0.047	0.004
	2.5	0.4	0.055	0.060	0.060	0.050	0.065	0.058	0.006
Chitosan film	1	0	0.013	0.015	0.013	0.015	0.010	0.013	0.002
	1.5	0	0.025	0.020	0.020	0.025	0.015	0.021	0.004
	2	0	0.025	0.035	0.025	0.035	0.035	0.031	0.005
	2.5	0	0.040	0.045	0.040	0.040	0.040	0.041	0.002

Table 4.4 Physical characteristics of film that prepared from 1, 1.5, 2 and 2.5% chitosan with 0.4% Ti (TiO₂/chitosan film) and without Ti content(chitosan film)

Types of film	Chitosan contents (%)	Ti contents (%)	Weight of slurry (g)	characteristics			
				Transparency	Acid smell	Coarseness of film surface	
						Exposed air	Contacted glass plate
TiO ₂ /chitosan film	1	0.4	5	X	X	O	X
	1.5	0.4	5	X	X	O	X
	2	0.4	5	X	X	O	X
	2.5	0.4	5	X	X	O	X
Chitosan film	1	-	5	O	X	O	X
	1.5	-	5	O	X	O	X
	2	-	5	O	X	O	X
	2.5	-	5	O	X	O	X

O = Showing characteristic

X = Not showing characteristic

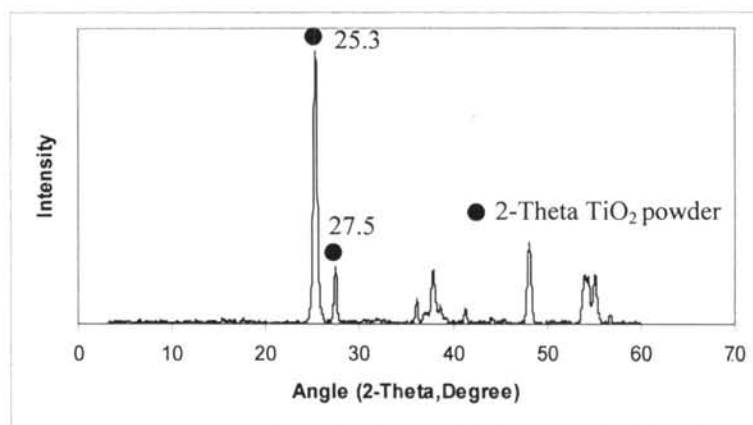
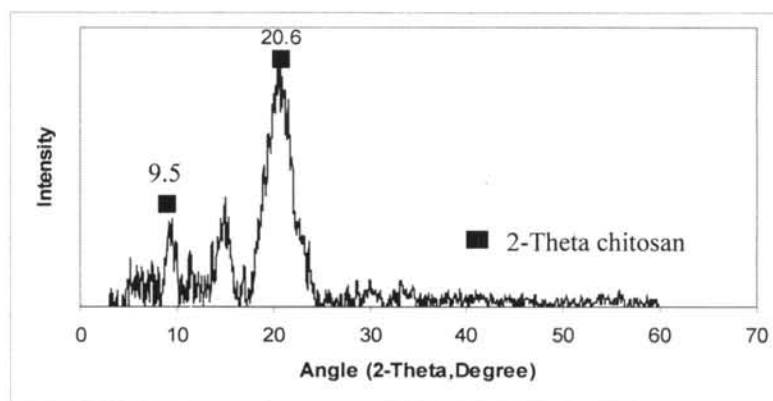
4.1.2 Crystal structures of TiO₂/chitosan and chitosan films

The XRD pattern of TiO₂ powder represent in figure 4.3 (a). TiO₂ crystalline was mainly composed of anatase phase as shown by the main peak of 2- Theta at 25.3 degree was anatase phase and 2- Theta at 27.5 degree was rutile phase.

Crystallizations of TiO₂/chitosan and chitosan film were checked with Power X-Ray Diffractometer (XRD). Normally, chitin-chitosan was outstanding demonstrated peak of 2- Theta in two position were at 9 and 19 degree. So The 2- Theta at 9 and 19 degree were amino acid structure position which were a agile group to react with chitosan reaction (Sappawinyoo, 2002).

Results of crystallization of TiO₂/chitosan and chitosan films show in figure 4.3 (b - e) which could be described that peaks of 2-Theta. Chitosan film was outstanding demonstrated peaks of 2- Theta in three positions which were at 9.5, 15.5 and 20.5 degree(Figure 4.20). So The 2- Theta at 9.5 and 20.5 degree were amino acid structure position which was a agile group to react with chitosan reaction and 15 degree was a water crystallize structure 25.3 degree was anatase phase and 27.5 degree was rutile phase.

From synthesis XRD spectra results could be confirmed that chitosan and TiO₂/chitosan films that prepared from this method had no change in identity of chitosan and TiO₂ (Figure 4.4). However, TiO₂/chitosan and chitosan films that analyzed by XRD were prepared form 1% and 2.5% chitosan contents which were the minimum and maximum percentage of chitosan in this experiment and both of the films were maintained clear pattern of chitosan and TiO₂.

a) TiO₂ powder

b) Chitosan film(1%chitosan, 0%Ti)

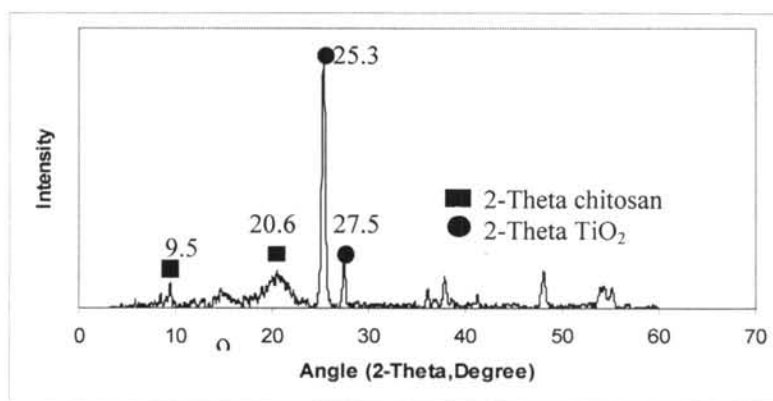
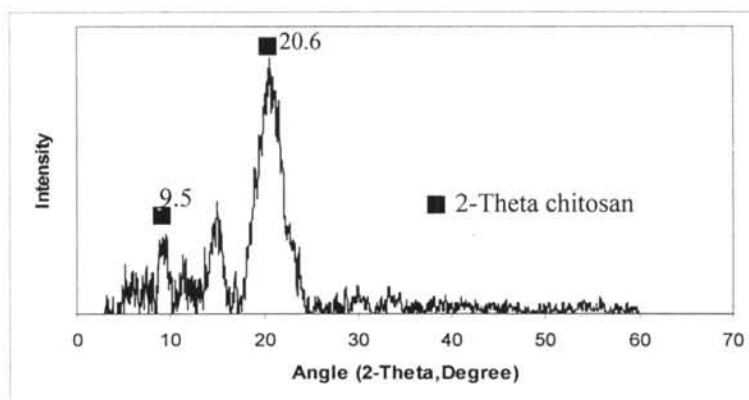
c) TiO₂/chitosan films(1%chitosan, 0.4%Ti)

Figure 4.3 X-ray diffraction patterns of a) TiO₂ powder, b) Chitosan film (1% chitosan, 0% Ti), c) TiO₂/chitosan film (1% chitosan, 0.4%Ti) d) Chitosan film (2.5% chitosan, 0%Ti) and e) TiO₂/chitosan film (2.5% chitosan, 0.4%Ti)



d) Chitosan film(2.5%chitosan, 0%Ti)

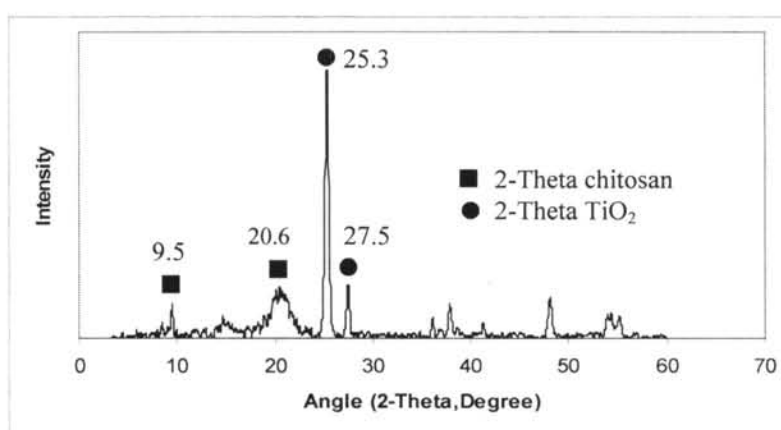
e) TiO₂/chitosan films (2.5%chitosan, 0.4%Ti)

Figure 4.3(cont) X-ray diffraction patterns of a) TiO₂ powder, b) Chitosan film (1% chitosan, 0% Ti), c) TiO₂/chitosan film (1% chitosan, 0.4% Ti) d) Chitosan film (2.5% chitosan, 0% Ti) and e) TiO₂/chitosan film (2.5% chitosan, 0.4% Ti)

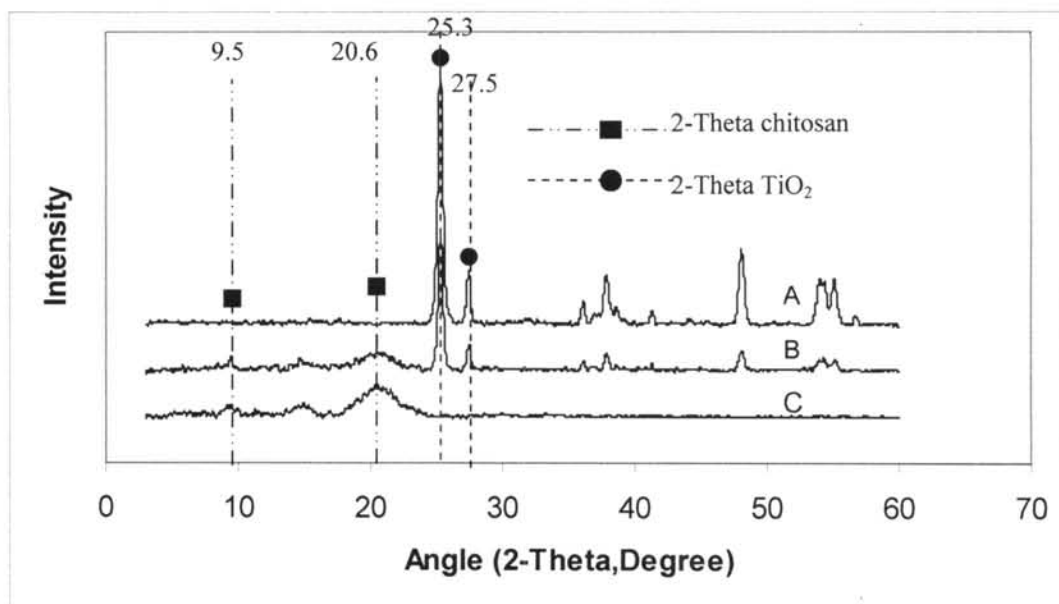
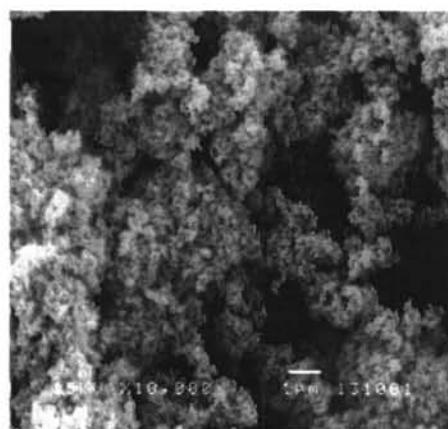
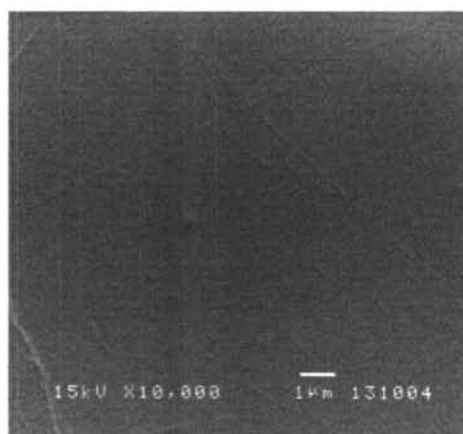


Figure 4.4 X-ray diffraction patterns of the comparison between TiO_2 powder(A) and TiO_2 /chitosan film(B) and chitosan film(C)

4.1.3 Surface morphology of TiO_2 /chitosan and chitosan films analyzed by SEM

In this study, TiO_2 powder, TiO_2 /chitosan and chitosan films were analyzed by using Scanning Electron Microscope (SEM) which was used at 10000 times in order to observe surface morphology (Figure 4.5). Results of this study shown that TiO_2 powder was agglomerated as particle. For chitosan film, the surface was flat and smooth which shows that chitosan was a homogeneous film before using for chromium(VI) removal. When TiO_2 composed with chitosan (TiO_2 /chitosan film) which found that TiO_2 particles were non-uniform scattered into chitosan. In this study one condition of TiO_2 /chitosan film has been shown since surface morphology of chitosan and TiO_2 /chitosan films that prepared from variation of chitosan contents have no different in surface morphology.

a) TiO₂ powder

b) Chitosan film (1%chitosan,0%Ti)

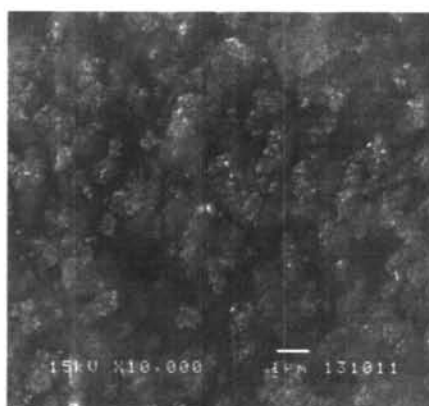
c) TiO₂/chitosan film (1% chitosan,0.4% Ti)

Figure 4.5 Scanning electron micrographs of a) TiO₂ powder, b) Chitosan film and c) TiO₂/chitosan film

4.1.4 Treating of chromium (IV) using synthesized TiO₂/chitosan and chitosan films

In this experimental set, chromium(IV) solution was prepared by dissolving potassium chromate in distilled water. The pH of the resultant solution was adjusted to pH 3 with diluted H₂SO₄. In this work, the treating of chromium was divided in to two process as follow: adsorption and photocatalytic processes.

Figure 4.6 shows about $\text{TiO}_2/\text{chitosan}$, chitosan film and TiO_2 powder for removing 100 mg/L chromium(VI) concentration. It was obvious that with TiO_2 powder alone (0% chitosan, 0.4% Ti), the removal efficiency was only 5.08 %. In addition, using chitosan only, the highest efficiency was 31.06 % with the maximum chitosan content (2.5% chitosan, 0%Ti). The $\text{TiO}_2/\text{chitosan}$ film that the film which prepared from 2.5% chitosan with 0.4% Ti could completely remove 100 mg/L chromium(VI) concentration. It was clearly seen that the film with 2.5% chitosan, 0.4% Ti provided the performance (100% chromium(VI) removal) with the shortest treatment period.

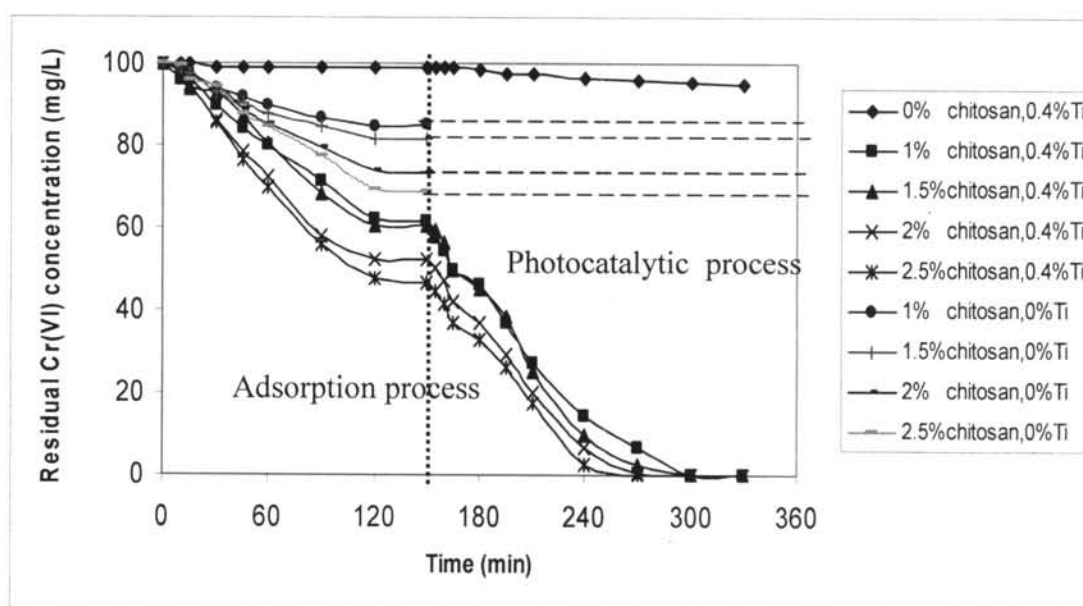


Figure 4.6 Removal of 100 mg/L chromium(IV) concentration using synthesized films that prepared from 1, 1.5, 2 and 2.5% chitosan with 0.4% Ti ($\text{TiO}_2/\text{chitosan}$ film) and without Ti content(chitosan film) in adsorption and photocatalytic processes

For chitosan films were used only adsorption process but the phenomonal of chitosan films for treating chromium(VI) in photocatalytic process were predicted that after illumination process, residual concentration of chromium(VI) in solution was not decreased because chitosan film is not semiconductor therefore photoreduction activity was not occurred. Efficiency of TiO₂/chitosan film in adsorption and photocatalytic processes show in table 4.5.

Table 4.5 Percentage removals of 100 mg/L chromium(VI) by using synthesized films that prepared from 1, 1.5, 2 and 2.5% chitosan with 0.4% Ti (TiO₂/chitosan film) and without Ti content(chitosan film) in adsorption and photocatalytic processes.

Types of film	Chitosan contents (%)	Ti contents (%)	Initial concentration of chromium(VI) (mg/L)	% Removal of chromium(VI) at the end of adsorption process	% Removal of chromium(VI) at the end of photocatalytic process
TiO ₂ /chitosan film	1	0.4	100	38.35	100
	1.5	0.4	100	43.36	100
	2	0.4	100	48.56	100
	2.5	0.4	100	53.22	100
Chitosan film	1	-	100	15.03	-
	1.5	-	100	18.64	-
	2	-	100	26.55	-
	2.5	-	100	31.06	-
TiO ₂ powder	0	0.4	100	0.84	5.08

4.1.4.1 Determination of adsorption isotherm of TiO₂/chitosan films in different chitosan contents

Table 4.6 demonstrates the adsorption of 100 mg/L chromium(VI) concentration on TiO₂/chitosan and chitosan films surface. Comparison between TiO₂ powder, TiO₂/chitosan film could remove chromium(VI) with efficiency as 38.35 - 53.22 % whereas chitosan film could remove with efficiency as 15.03 – 31.06% and TiO₂ powder could only remove at 0.84 %. Chromium removal efficiency range of TiO₂/chitosan film was higher than chromium removal efficiency range of chitosan film and TiO₂ powder. For TiO₂/chitosan film prepared in different chitosan contents (1, 1.5, 2 and 2.5%) with 0.4% Ti, the result shown that TiO₂/chitosan film was prepared from 2.5% chitosan, 0.4% Ti provided the highest efficiency(31.06%) for chromium(VI) removal. The reason that at the 2.5% of chitosan was the best efficiency for chromium (VI) removal. The reason might become the fact that the maximum quantity of chitosan which provided maximum protonated amino group (-NH₃⁺) which was a functional of chitosan biopolymer, the sorbent was positively charged with protonated as amino group whereas the sorbate was negatively charged, (chromium (VI) existed as HCrO₄⁻). In view of electrostatic interaction between the sorbent-sorbate systems. The pH should be maintained at pH 3 in further experiments (Sankararamakrishnan et al.,2005).

From 100 mg/L chromium (VI) removal experiment, the result shown that TiO₂/chitosan film could effectively adsorbed chromium (VI). This result was shown in same result as Ding et. al., 2006 with the fact that chitosan is a powerful chelating agent, which is easy to form complexes with transition metals and heavy metals such as Cr⁺⁶ Zn⁺². Therefore, in this research it was necessary to study about TiO₂/chitosan film adsorption behavior.

The results depict in figure 4.7, the equilibration time for the physico-chemical reaction between chromium(VI) and TiO₂/chitosan film in each condition at pH 3. As seen from the graph, adsorption of chromium(VI) on TiO₂/chitosan film surface occur during the equilibration period. The amount of chromium(VI) adsorbed was increased with time and attained equilibrium within 120 min. This indicates the

equilibration time required for maximum chromium(VI) adsorption on TiO₂/chitosan film surface.

Table 4.6 Percentage removals of 100 mg/L chromium(VI) by using synthesized films that prepared from 1, 1.5, 2 and 2.5% chitosan with 0.4% Ti (TiO₂/chitosan film) and without Ti content(chitosan film) in adsorption process

Types of film	Chitosan contents (%)	Ti contents (%)	Initial concentration of chromium(VI) (mg/L)	x/m at the end of adsorption process (mg of Cr(VI)/g of film)	% Removal
TiO ₂ /chitosan film	1	0.4	100	457.68	38.35
	1.5	0.4	100	420.11	43.36
	2	0.4	100	405.58	48.56
	2.5	0.4	100	351.82	53.22
Chitosan film	1	-	100	268.75	15.03
	1.5	-	100	252.23	18.64
	2	-	100	244.98	26.55
	2.5	-	100	230.70	31.06
TiO ₂ powder	0	0.4	100	28.72	0.84

Langmuir equation was applied for adsorption equilibrium of chromium(VI) onto TiO₂/chitosan film surfaces. The Langmuir adsorption isotherm was based on these assumptions: (i) maximum adsorption corresponds to a saturated monolayer of adsorbate molecules on the adsorbent surface: (ii) the energy of adsorption is constant: and (iii) there is no transmigration of adsorbate in surface plane (Kajitvichyanukul et al.,2004) . The Langmuir equation was shown below:

$$C_e/(x/m) = 1/(Q_o b) + C_e/Q_o \quad (\text{Eq. 4.1})$$

Where C_e is the equilibrium concentration of chromium(VI), mg/L, x/m is amount of adsorbed chromium(VI) at equilibrium per unit mass of TiO₂/chitosan film, mg/g , Q_o is maximum adsorption at monolayer coverage, mg /g, and b is Langmuir constant related to the affinity of binding sites, L/mg and it is a measure of energy of adsorption. The linear plot of $C_e/(x/m)$ vs C_e in figure 4.8 show that the adsorption of chromium(VI) onto TiO₂/chitosan film surface in each condition obeys Langmuir adsorption isotherm. The correlation coefficient for the linear regression fit of the Langmuir plot and the expressed equation present in table 4.10.

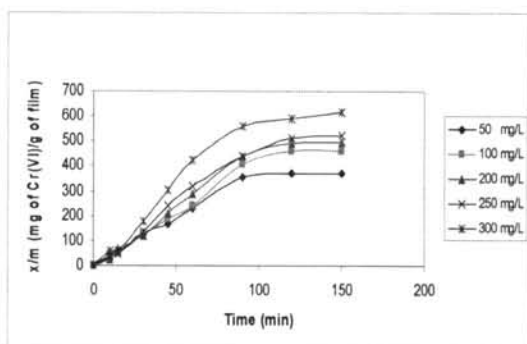
The essential characteristic of the Langmuir isotherm can be expressed in term of a dimensionless constant separation factor or equilibrium parameter, R_L , which is defined by (Mackay et al., 1982)

$$R_L = 1/(1 + bC_o) \quad (\text{Eq. 4.2})$$

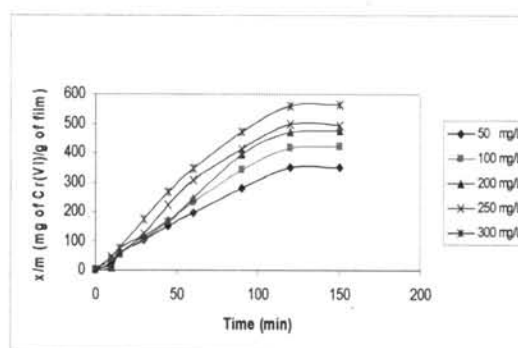
Where b is Langmuir constant, and C_o is initial concentration of chromium(VI). The parameter indicates the adsorption isotherms show in table 4.7. The values of R_L in this experiment set were calculated (Table 4.8) and it was found that all R_L values were between 0 and 1, indicating favorable chromium(VI) adsorption onto each TiO₂/chitosan film surface.

Table 4.7 R_L values and behaviors of Isotherm

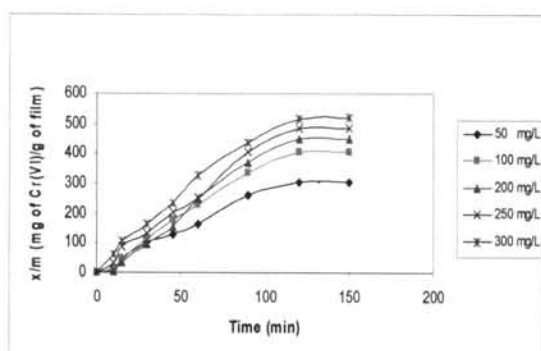
R_L Value	Behaviors of Isotherm
$R_L > 1$	Unfavorable
$0 < R_L < 1$	Favorable
$R_L = 0$	Irreversible



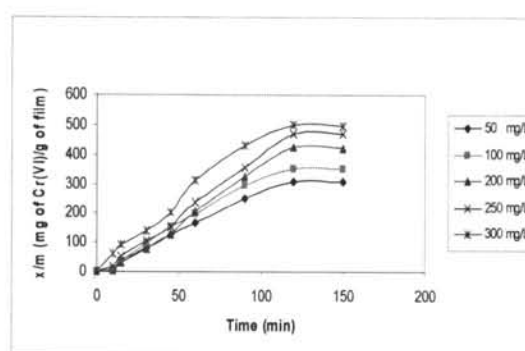
a) 1% chitosan, 0.4% Ti



b) 1.5% chitosan, 0.4% Ti



c) 2% chitosan, 0.4% Ti



d) 2.5% chitosan, 0.4% Ti

Figure 4.7 Adsorption of chromium(VI) on TiO_2 /chitosan film that prepared from a) 1% chitosan, 0.4% Ti, b) 1.5% chitosan, 0.4% Ti, c) 2% chitosan, 0.4% Ti and d) 2.5% chitosan, 0.4% Ti in different initial concentrations of chromium(VI)

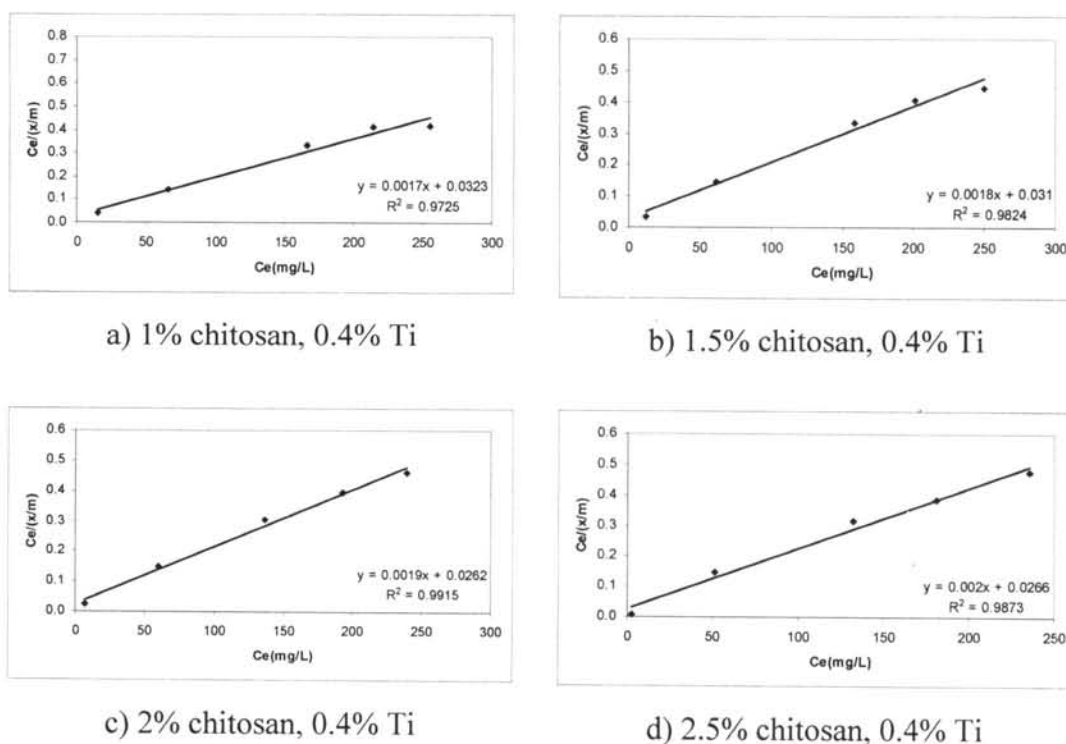


Figure 4.8 Langmuir adsorption isotherms plot for adsorption of chromium(VI) on TiO_2 /chitosan film that prepared from a) 1% chitosan, 0.4% Ti, b) 1.5% chitosan, 0.4% Ti, c) 2% chitosan, 0.4% Ti and d) 2.5% chitosan, 0.4% Ti

Table 4.8 R_L Values for Langmuir adsorption isotherm for TiO_2 /chitosan film that prepared from 1, 1.5, 2 and 2.5% chitosan with 0.4% Ti

Initial concentrations of chromium(VI) (mg/L)	R_L Values of TiO_2 /chitosan film (1%chitosan, 0.4%Ti)	R_L Values of TiO_2 /chitosan film (1.5%chitosan, 0.4%Ti)	R_L Values of TiO_2 /chitosan film (2%chitosan, 0.4%Ti)	R_L Values of TiO_2 /chitosan film (2.5%chitosan, 0.4%Ti)
50	0.275	0.256	0.216	0.210
100	0.160	0.147	0.121	0.117
200	0.087	0.079	0.065	0.062
250	0.071	0.064	0.052	0.051
300	0.060	0.054	0.044	0.042

Table 4.9 Q_0 and b values for Langmuir adsorption isotherm for TiO₂/chitosan film that prepared from 1, 1.5, 2 and 2.5% chitosan with 0.4% Ti

Adsorption Isotherm	Chitosan contents (%)	Ti contents (%)	Q_0 (mg/g)	b (L/mg)
Langmuir	1	0.4	588	0.053
	1.5	0.4	555	0.058
	2	0.4	526	0.073
	2.5	0.4	500	0.075

Figure 4.9 shows about the relation between Q_0 (the maximum adsorption at monolayer coverage, mg of chromium /g of film) and chitosan content which shown that the maximum adsorption at monolayer coverage was decreased with the increasing of chitosan content on TiO₂ /chitosan film. This phenomenon might come from the fact that increasing of chitosan content obvioued that x value was increased and m is also increased. However, the increase of m , g (mass of film) was much more higher than the increase of x , mg(amount of adsorbed chromium(VI)). Thus the x/m value for high concentration of percent chitosan (such as 1.5% chitosan) will be less than lower chitosan (1% chitosan) by on the Q_0 value as shown in the equation 4.1. On the other hand, figure 4.10 shows about the relation between b which is a measure of the energy of adsorption.(L/mg) and chitosan content which found that measure of the energy of adsorption was increased with the increasing of chitosan content on TiO₂ chitosan film. This result might come from the fact that higher chitosan content, the more energy of chitosan film adsorption (Sappawinyoo, 2004). The Langmuir constants, Q_0 and b values were determined form the Langmuir plot which show in table 4.9.

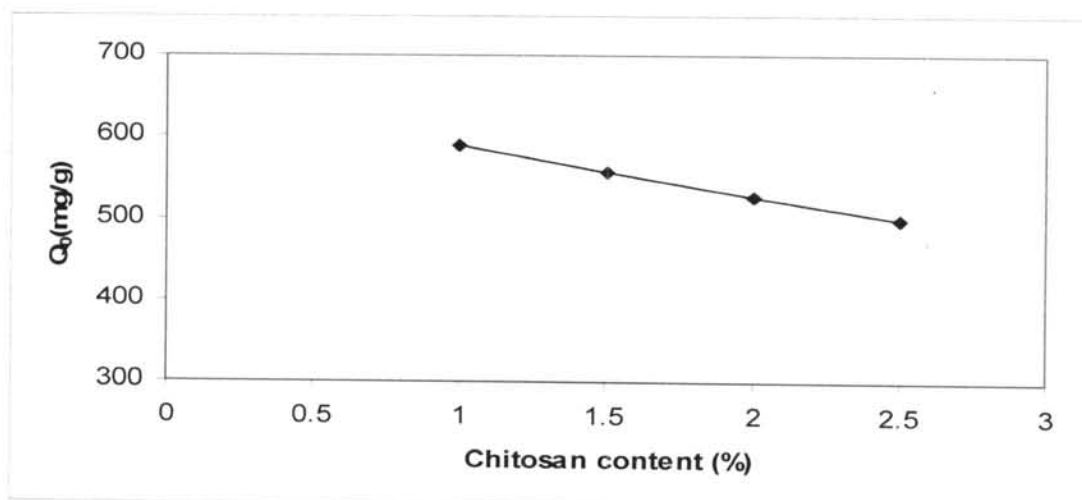


Figure 4.9 Plotting of relation between Q_0 and chitosan contents

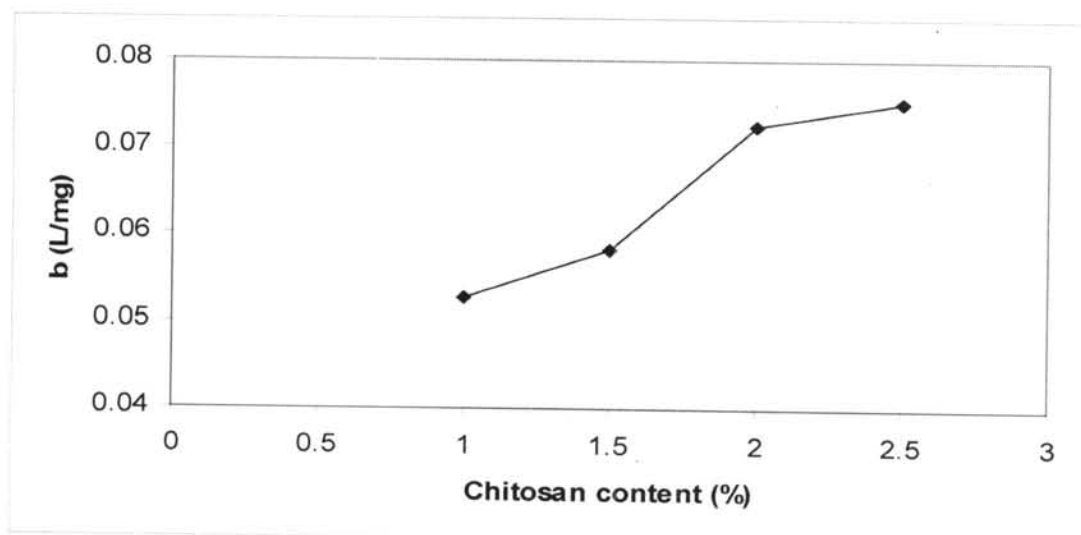


Figure 4.10 Plotting of relation between b and chitosan contents

Freundlich equation was also applied to adsorption of chromium(VI) onto TiO_2 /chitosan film surface. The Freundlich equation is basically empirical, and generally agrees with the experimental data over a moderate range of adsorbate concentrations. The Freundlich isotherm is represented by the equation (Mckay et., al 1982)

$$\text{Log}(x/m) = (1/n)\text{log}C_e + \text{log}k_f \quad (\text{Eq. 4.3})$$

Where C_e is the equilibrium concentration of chromium(VI), mg/L, x/m is the amount of adsorbed chromium(VI) at equilibrium per unit mass of $\text{TiO}_2/\text{chitosan}$ film, mg/g, k_f and n are the Freundlich constants. The plot of $\log(x/m)$ versus $\log C_e$ based on equation was shown above for the same experimental results show in figure 4.11. The correlation coefficient for linear regression fit of the Freundlich plot and the expressed equations present in table 4.10.

The correlation coefficient for linear regression fit of Langmuir plot in each condition of $\text{TiO}_2/\text{chitosan}$ film (1, 1.5, 2 and 2.5% chitosan with 0.4% Ti) were found to be 0.9963, 0.9824, 0.9873 and 0.9757 while the correlation coefficient for the Freundlich plot in each condition of $\text{TiO}_2/\text{chitosan}$ film(1, 1.5, 2 and 2.5% chitosan with 0.4% Ti) were found to 0.9931, 0.9352, 0.8271 and 0.7748, respectively which were less than that from Langmuir plot. The value of correlation coefficient of Chromium(VI) adsorption indicates that adsorption behavior of chromium(VI) onto $\text{TiO}_2/\text{chitosan}$ film tends to be a monolayer adsorption as described by Langmuir isotherm rather than Freundlich isotherm.

Table 4.10 Langmuir and Freundlich adsorption isotherms for $\text{TiO}_2/\text{chitosan}$ film that prepared from 1, 1.5, 2 and 2.5% chitosan with 0.4 % Ti

Adsorption Isotherms	Chitosan contents (%)	Ti contents (%)	Equations	R^2
Langmuir	1	0.4	$C_e/(x/m) = 0.0017C_e + 0.0323$	0.9963
	1.5	0.4	$C_e/(x/m) = 0.0018C_e + 0.031$	0.9824
	2	0.4	$C_e/(x/m) = 0.0019C_e + 0.0262$	0.9873
	2.5	0.4	$C_e/(x/m) = 0.002C_e + 0.0266$	0.9757
Freundlich	1	0.4	$\log(x/m) = 0.1493\log C_e + 2.3892$	0.9931
	1.5	0.4	$\log(x/m) = 0.1403\log C_e + 2.383$	0.9352
	2	0.4	$\log(x/m) = 0.1434\log C_e + 2.3592$	0.8271
	2.5	0.4	$\log(x/m) = 0.1006\log C_e + 2.4257$	0.7748

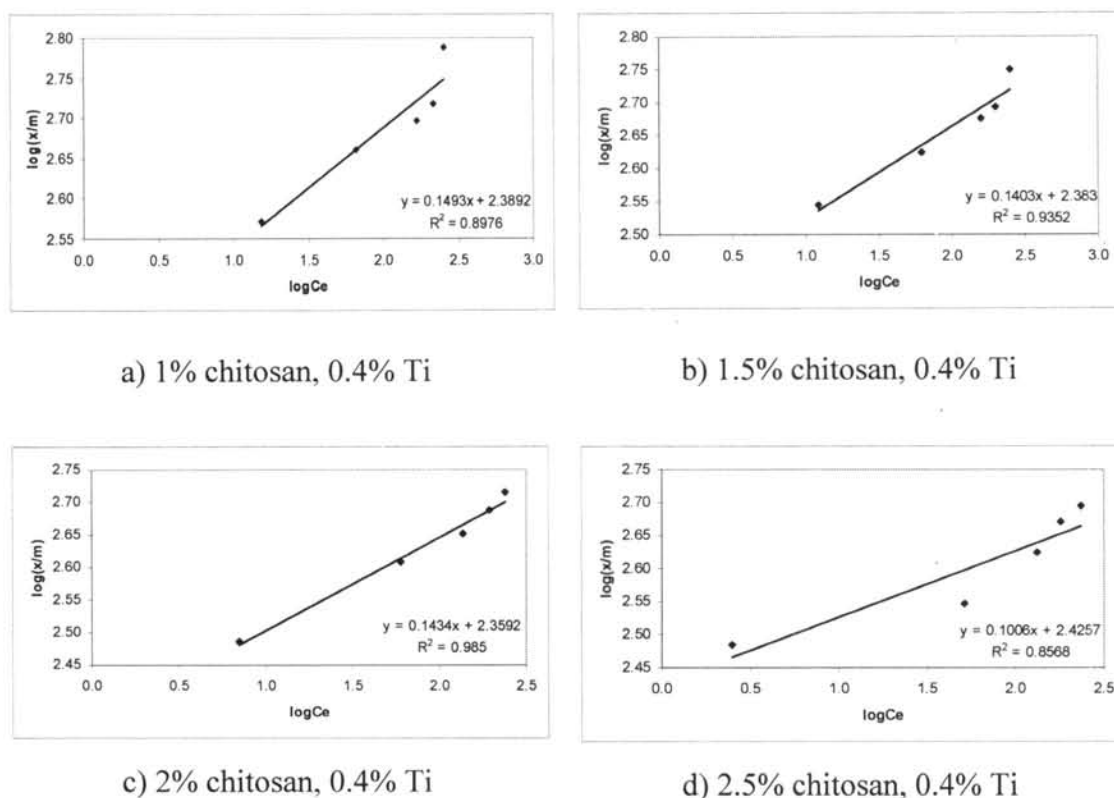


Figure 4.11 Freundlich adsorption isotherm plot for adsorption of chromium(VI) on TiO_2 /chitosan film that prepared from a) 1% chitosan, 0.4% Ti, b) 1.5% chitosan, 0.4% Ti, c) 2% chitosan, 0.4% Ti and d) 2.5% chitosan, 0.4% Ti

4.1.4.2 Determination of kinetic values in photocatalytic reduction of chromium(VI) using TiO_2 /chitosan films in variation of chitosan contents.

The photocatalytic reductions of chromium (VI) with TiO_2 /chitosan film that prepared from 1, 1.5, 2 and 2.5% chitosan with 0.4% Ti in variation of initial concentrations of chromium(VI) in the range of 50 – 300 mg/L were conducted. The results of this experimental part were shown about residual fraction of chromium (VI) (Figure 4.13). It was obvious that the efficiency in chromium (VI) removal decreased with the increasing of initial concentration of chromium (VI) in solution. To explain the behavior of photocatalytic reduction of chromium (VI) by synthesized TiO_2 /chitosan film for each condition in term of kinetic study, two patterns of kinetic orders, which are zero-order and pseudo-first order equations are considered. As seen in chromium (VI) declining pattern, the kinetic order to explain the existed reaction

can be either zero order or pseudo first order. Thus, the value of k_{obs} can be calculated by the both equations.

At $n=0$, the reaction is zero-order which is one in the rate of reaction independent of the concentration of solution. The zero-order equation can be derived a follow:

$$\frac{dc}{dt} = -k_{obs}[C]^n - k_{obs}[C]^0 = -k_{obs} \quad (\text{Eq. 4.4})$$

$$dc = -k_{obs}(dt) \quad (\text{Eq. 4.5})$$

$$\int_{c_0}^c dC = -k_{obs} \int_0^t dt \quad (\text{Eq. 4.6})$$

$$C - C_0 = -k_{obs}t \quad (\text{Eq. 4.7})$$

Where k_{obs} is the apparent reaction rate constant, n is the order of the reaction, t is the reaction time, C_0 is the initial concentration of chromium (VI) in aqueous solution, and C is the residual concentration of chromium (VI) at time t . Value of k_{obs} was determined from the slope of graph which was plot between $C-C_0$ and reaction time, t . The value R^2 for linear regression was calculated to exhibit the tendency of the reaction pattern to be describe as a zero-order pattern. Values of k_{obs} from zero-order equation were determincd as show in table 4.11-4.14.

At $n=1$, the reaction first order which is the rate of reaction which can be obtained by the following relationship of concentration of solution and time. The first order equation can be derived a follow:

$$\frac{dc}{dt} = -k_{obs}[C]^n - k_{obs}[C]^1 \quad (\text{Eq. 4.8})$$

$$\frac{1}{[C]} d[C] = -k_{obs} dt \quad (\text{Eq. 4.9})$$

$$\frac{1}{[C]} \int_{c_0}^c dC = -k_{obs} \int_0^t dt \quad (\text{Eq. 4.10})$$

$$\ln\left(\frac{C}{C_0}\right) = -k_{obs}t \quad (\text{Eq. 4.11})$$

Where k_{obs} is the apparent reaction rate constant, n is the order of the reaction, t is the reaction time, C_0 is the initial concentration of chromium (VI) in aqueous solution, and C is the residual concentration of chromium (VI) at time t . Values of k_{obs} was

determined from the slope of graph which was plot between $-\ln(C/C_0)$ and reaction time, t (Figure 4.14). The value R^2 for linear regression was calculated to exhibit the tendency of the reaction pattern to be described as pseudo-first order. Values of k_{obs} from pseudo-first order equation were determined as show in table 4.11-4.14.

The photocatalytic reduction of 100 mg/L chromium (VI) concentration under irradiation process for $\text{TiO}_2/\text{chitosan}$ film with different chitosan contents were compared. The ratio of residual to initial concentration of chromium(VI) in term of C/C_0 as a function of irradiation time illustrate in figure 4.12. It is obvious that the $\text{TiO}_2/\text{chitosan}$ film provided the higher efficiency in chromium(VI) removal comparing to TiO_2 powder or 0% chitosan,0.4%Ti. In consideration of treating efficiency of chromium(VI) using different chitosan contents that prepared from 1, 1.5, 2 and 2.5% with 0.4%, the result shown that chitosan at 2.5% provided the highest efficiency for chromium (VI) removal and the lower chromium (VI) efficiency were 2, 1.5 and 1%, respectively.

Considering the pattern of kinetic equation, the photocatalytic reduction reactions of $\text{TiO}_2/\text{chitosan}$ film in different chitosan contents can be represented by pseudo-first order pattern for initial chromium(VI) concentration in range of 50-300 mg/L because the correlation coefficients (R^2) value of zero order less than that correlation coefficients value from pseudo-first order.

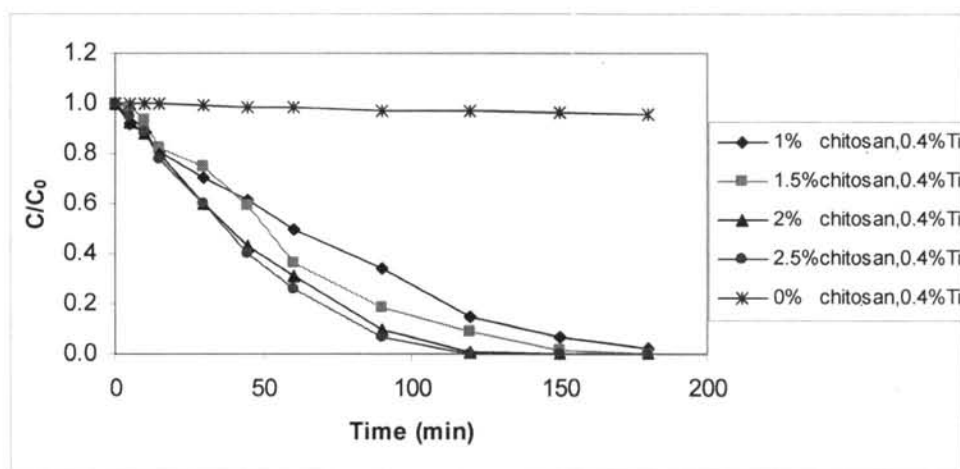


Figure 4.12 Residual fraction of 100 mg/L chromium (VI) in different chitosan contents on $\text{TiO}_2/\text{chitosan}$ film

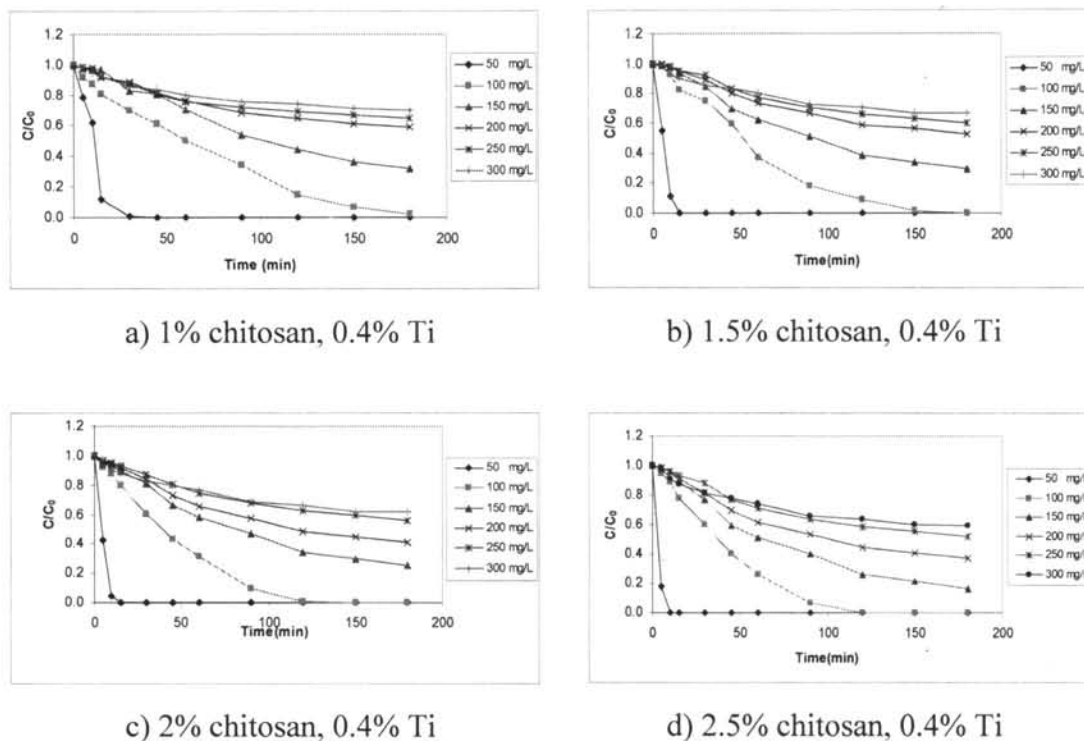


Figure 4.13 Residual fraction of chromium (VI) in different initial concentrations for $\text{TiO}_2/\text{chitosan}$ film that prepared from a) 1% chitosan, 0.4% Ti, b) 1.5% chitosan, 0.4% Ti, c) 2% chitosan, 0.4% Ti and d) 2.5% chitosan, 0.4% Ti

The photocatalytic reduction reactions of $\text{TiO}_2/\text{chitosan}$ film in different chitosan contents were described by pseudo-first order pattern. As chromium(VI) concentration increased with fixed dosage of $\text{TiO}_2/\text{chitosan}$ film in the system, the reaction became dependent on both concentration of chromium(VI) and reaction time. The plotting of k_{obs} from pseudo-first order as a function of chitosan content on $\text{TiO}_2/\text{chitosan}$ film from each condition that removed 100 mg/L chromium(VI) concentration is shown in figure 4.15. This figure shows that k_{obs} obtained from $\text{TiO}_2/\text{chitosan}$ film provided higher than k_{obs} from TiO_2 powder (0% chitosan, 0.4% Ti), 0.0003 min^{-1} . While k_{obs} of $\text{TiO}_2/\text{chitosan}$ film from 2.5% chitosan with 0.4% Ti (0.0255 min^{-1}) was higher than k_{obs} of $\text{TiO}_2/\text{chitosan}$ films in other conditions (Table 4.11-4.14). The reason for 2.5% chitosan with 0.4% Ti was the highest efficiency for chromium (VI) removal because $\text{TiO}_2/\text{chitosan}$ film that prepared from 2.5% chitosan with 0.4% Ti provides the maximum quantity of chitosan

that mean it provide maximum protonated amino group ($-\text{NH}_3^+$) which was a functional of chitosan biopolymer that help for adsorbed chromium(VI) into TiO_2 /chitosan film surface. The photocatalytic reaction was confined mostly to adsorption capacity of media under illumination. Therefore, the more adsorption capacity, the more photocatalytic reaction occurs(Yu et al.,2001).

Upon photocatalytic reduction of chromium(VI), TiO_2 /chitosan film that prepared from 2.5% chitosan with 0.4% provided the highest efficiency (0.0255 min^{-1}) which could remove 100% chromium(VI) in 100 mg/L initial concentration with the shortest period. Therefore 2.5% chitosan content was the best content for TiO_2 /chitosan film preparation and it was used in next experiment.

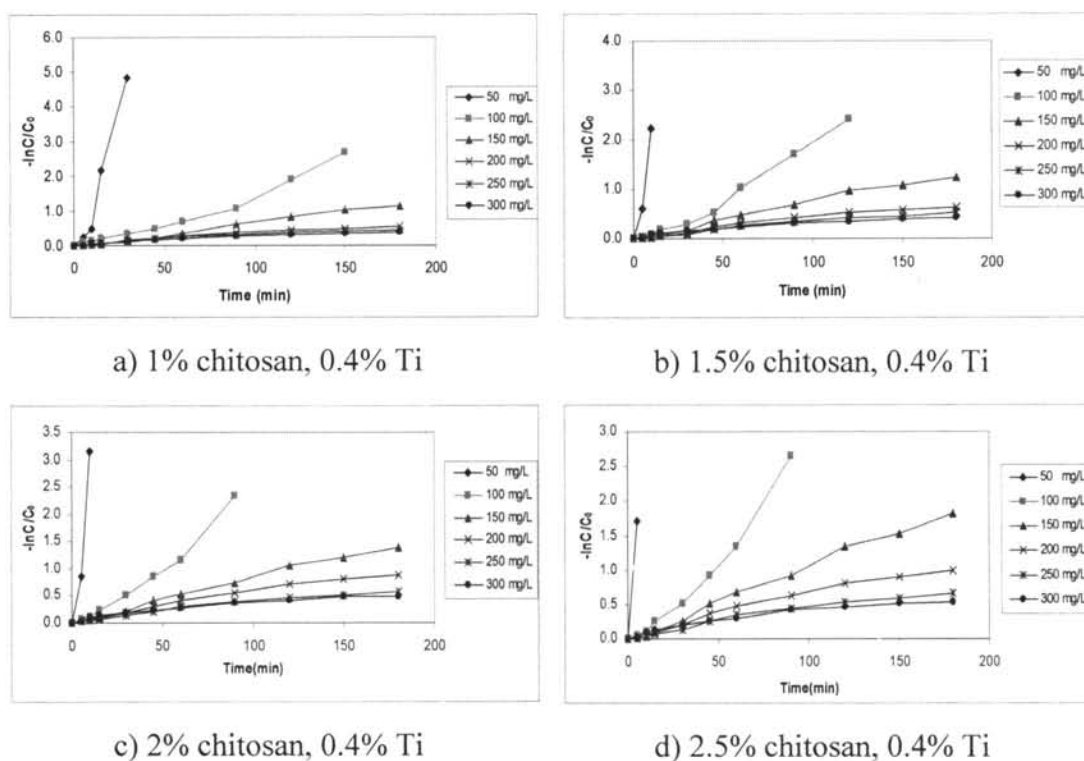


Figure 4.14 Relation between $-\ln(C/C_0)$ and time in different initial concentrations of chromium(VI) removal for TiO_2 /chitosan film that prepared from a) 1% chitosan, 0.4% Ti, b) 1.5% chitosan, 0.4% Ti, c) 2% chitosan, 0.4% Ti and d) 2.5% chitosan, 0.4% Ti

Table 4.11 Values of k_{obs} from pseudo-first order equation for photocatalytic process using TiO₂ /chitosan film that prepared from 1%chitosan, 0.4% Ti with 20% acetic acid solution

Initial concentrations of chromium(VI) (mg/L)	pseudo-first order		% Removal
	k_{obs} (min ⁻¹)	R^2	
50	0.1462	0.9143	100.00
100	0.0155	0.9527	98.78
150	0.0065	0.9888	78.09
200	0.0034	0.9613	54.88
250	0.0029	0.8768	48.21
300	0.0024	0.8340	42.29

Table 4.12 Values of k_{obs} from pseudo-first order equation for photocatalytic process using TiO₂ /chitosan film that prepared from 1.5 %chitosan, 0.4% Ti with 20% acetic acid solution.

Initial concentrations of chromium(VI) (mg/L)	pseudo-first order		% Removal
	k_{obs} (min ⁻¹)	R^2	
50	0.2012	0.9434	100.00
100	0.0183	0.9598	100.00
150	0.0073	0.9892	79.92
200	0.0040	0.9685	60.74
250	0.0032	0.9610	53.05
300	0.0028	0.8621	46.30

Table 4.13 Values of k_{obs} from pseudo-first order equation for photocatalytic process using TiO₂/chitosan film that prepared from 2 %chitosan, 0.4% Ti with 20% acetic acid solution.

Initial concentrations of chromium(VI) (mg/L)	pseudo-first order		% Removal
	k_{obs} (min ⁻¹)	R^2	
50	0.2868	0.9212	100
100	0.0226	0.9507	100
150	0.0081	0.9913	83.31
200	0.0055	0.9711	72.57
250	0.0036	0.9488	58.78
300	0.0033	0.8351	53.86

Table 4.14 Values of k_{obs} from pseudo-first order equation for photocatalytic process using TiO₂/chitosan film that prepared from 2.5%chitosan, 0.4% Ti with 20% acetic acid solution.

Initial concentrations of chromium(VI) (mg/L)	pseudo-first order		% Removal
	k_{obs} (min ⁻¹)	R^2	
50	-	-	100
100	0.0255	0.9436	100
150	0.0104	0.9937	89.78
200	0.0062	0.9666	75.76
250	0.0041	0.9477	62.41
300	0.0036	0.8421	56.42

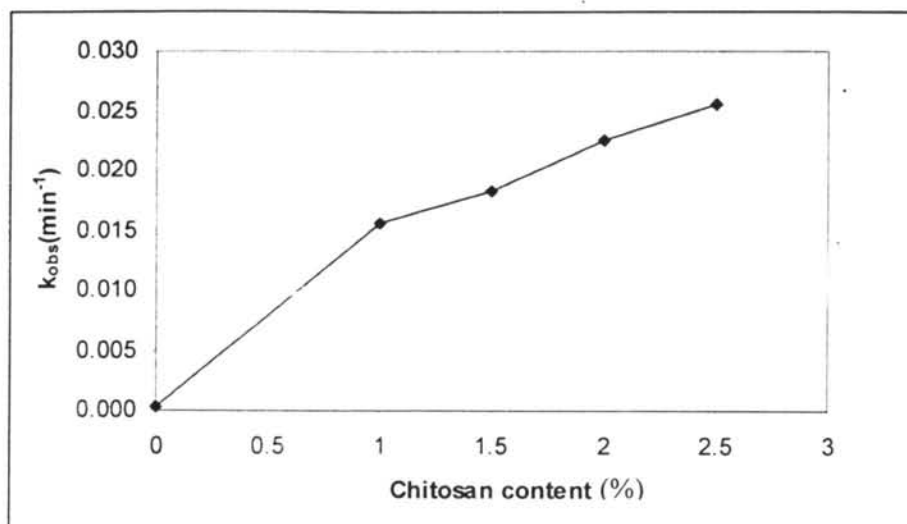


Figure 4.15 Comparison of apparent reaction rate constant (k_{obs}) for 100 mg/L chromium(VI) removal by using different chitosan contents.

The Langmuir-Hinshelwood rate expression has been successfully used for heterogeneous photocatalytic degradation to determine the relationship between the initial degradation rate and the initial concentration of chromium (VI) (Chen et al., 1998):

$$\frac{1}{k_{obs}} = \frac{1}{k \cdot K_{cr(VI)}} + \frac{[Cr(VI)]_o}{k} \quad (\text{Eq. 4.12})$$

Where $[Cr(VI)]_o$ is the initial concentration of chromium (VI) in the unit of mg/L

$K_{cr(VI)}$ is the Langmuir-Hinshelwood adsorption equilibrium constant in the unit of L/mg

k is the rate constant of surface reaction in the unit of mg/L.min

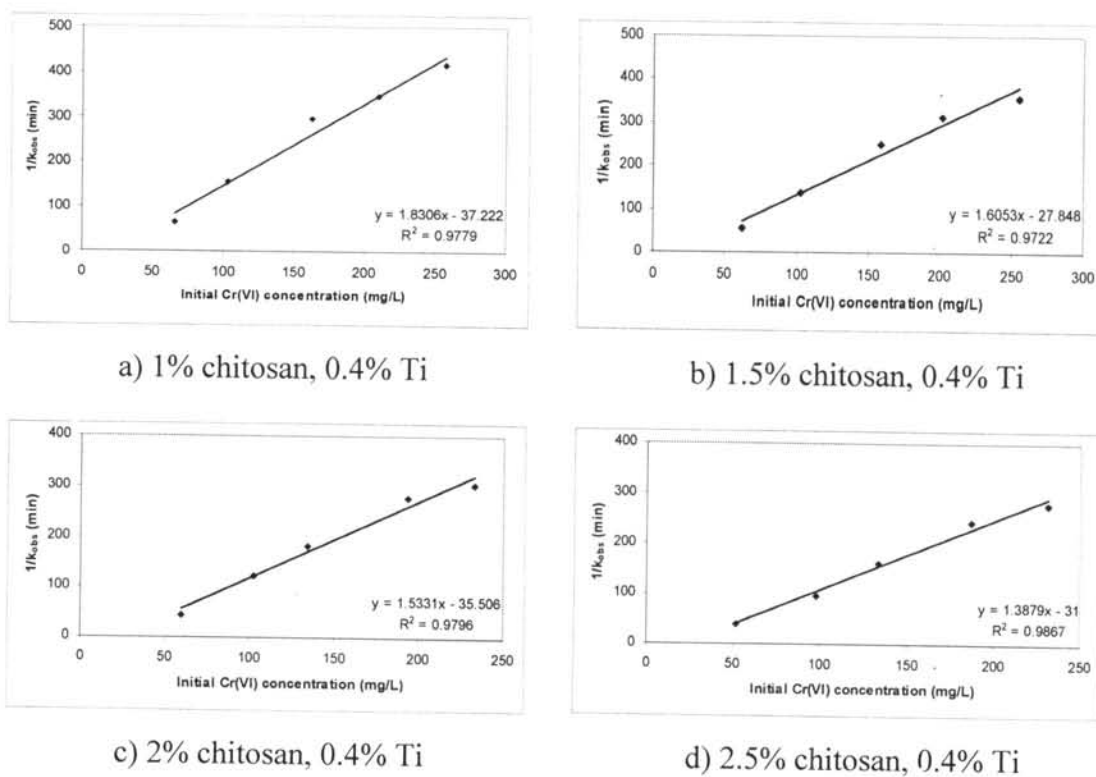


Figure 4.16 Determination of adsorption equilibrium constants and degradation rate constants chromium(VI) by using TiO_2 /chitosan film that prepared from a) 1% chitosan, 0.4% Ti, b) 1.5% chitosan, 0.4% Ti, c) 2% chitosan, 0.4% Ti and d) 2.5% chitosan, 0.4% Ti

Figure 4.16 shows the determination of the adsorption equilibrium constant and degradation rate constant for chromium (VI) in the range of initial concentrations 100 to 300 mg/L by plotting between $1/k_{obs}$ and initial chromium(VI) concentration. The Langmuir-Hinshelwood equations for photocatalytic process using TiO_2 /chitosan films in variation of chitosan contents which show in table 4.15.

Table 4.15 Langmuir-Hinshelwood equations for photocatalytic process using TiO₂/chitosan films in variation of chitosan contents

Chitosan contents (%)	Ti contents (%)	Langmuir-Hinshelwood Equations
		$\frac{1}{k_{obs}} = \frac{1}{k \cdot K_{cr(VI)}} + \frac{[Cr(VI)]_o}{k}$
1	0.4	$\frac{1}{k_{obs}} = \frac{1}{(0.546)(-0.049)} + \frac{[Cr(VI)]_o}{0.546}$
1.5	0.4	$\frac{1}{k_{obs}} = \frac{1}{(0.623)(-0.058)} + \frac{[Cr(VI)]_o}{0.623}$
2	0.4	$\frac{1}{k_{obs}} = \frac{1}{(0.652)(-0.043)} + \frac{[Cr(VI)]_o}{0.652}$
2.5	0.4	$\frac{1}{k_{obs}} = \frac{1}{(0.721)(-0.045)} + \frac{[Cr(VI)]_o}{0.721}$

4.2 Role of Ti content on TiO₂/chitosan film preparation.

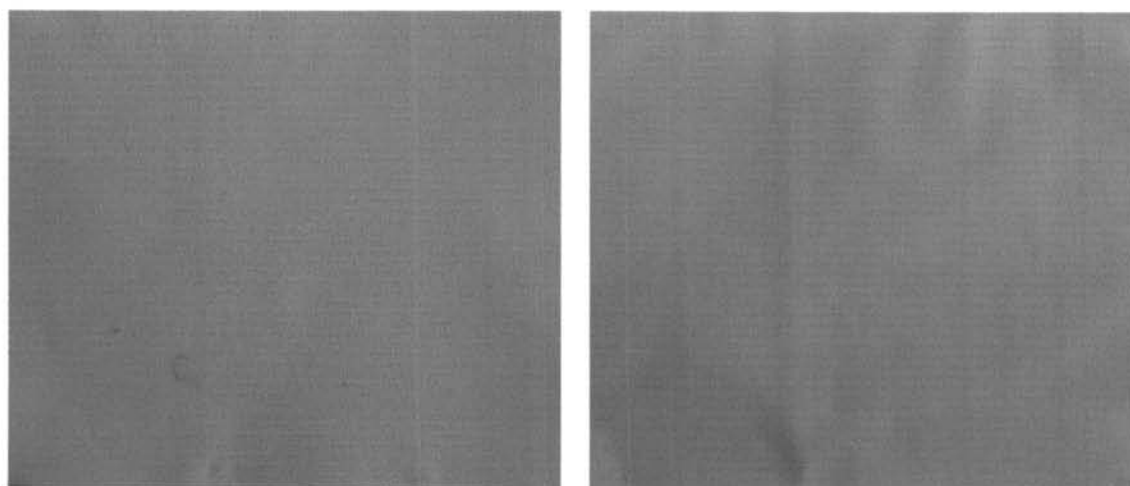
TiO₂/chitosan films in different Ti contents were prepared by dissolving 0.2, 0.4, 0.6 and 0.8 % w/w of Ti from TiO₂ powder with 2.5 % chitosan flake in 20% acetic acid solution for 24 hr. After that 5 g of slurry were taken and spread them on 5x6 cm glass plate then placed its in room temperature to dry for 48 hr. Next step peeled the film out from glass plate. However in step of mixing substances, the problem was occurred in condition 0.6% and 0.8% Ti with 2.5% chitosan which was the TiO₂/chitosan slurry could be not homogeneous and films that prepare from this condition were not smooth. While at 0.2 % and 0.4% Ti with 2.5% chitosan could be provided smooth films. The same problem existed when 2% of chitosan was used as show in table 4.16 but this problem was not occurred in using 1.5% of chitosan. The film is favorable with the mixing of TiO₂ in the range of 0.2-0.8% Ti. In step of mixing, all condition could be homogenous solution and provide smooth film (Figure 4.17-4.19).

Table 4.16 Film formation in each condition

Chitosan contents (%)	Ti contents (%)	Film formation
2.5	0.2	O
	0.4	O
	0.6	X
	0.8	X
2	0.2	O
	0.4	O
	0.6	X
	0.8	X
1.5	0.2	O
	0.4	O
	0.6	O
	0.8	O

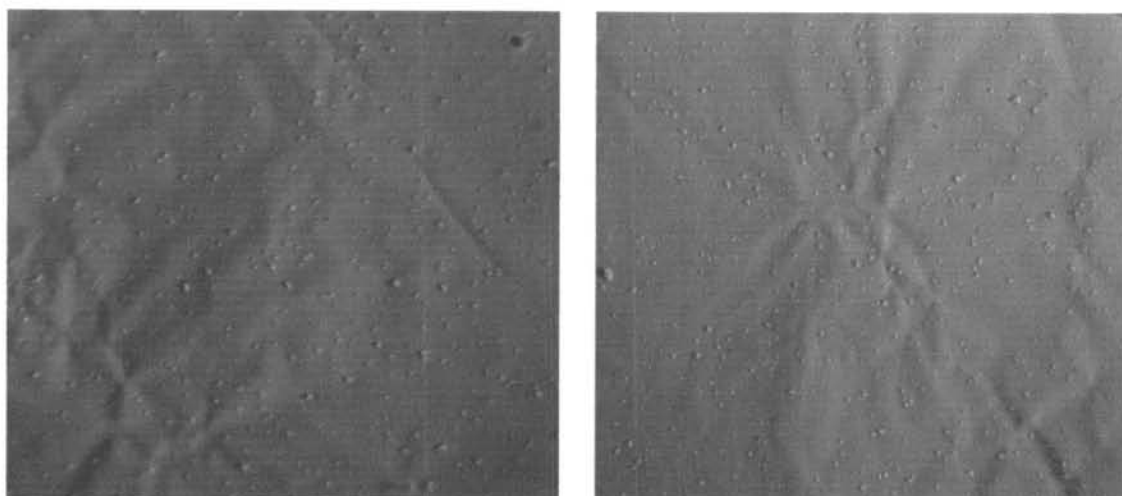
O = Can be used to prepare film

X = Can not be used to prepare film



a) 0.2%Ti, 2.5% chitosan

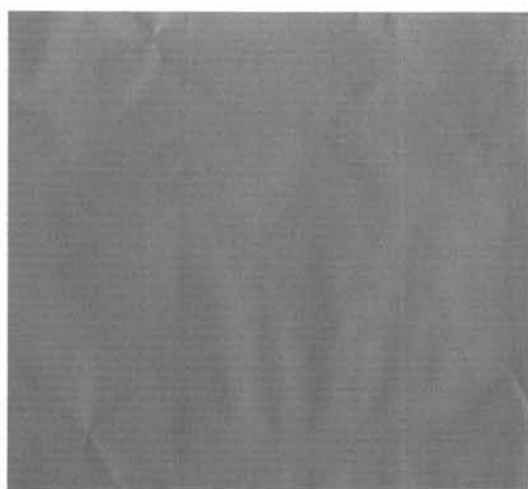
b) 0.4%Ti, 2.5% chitosan



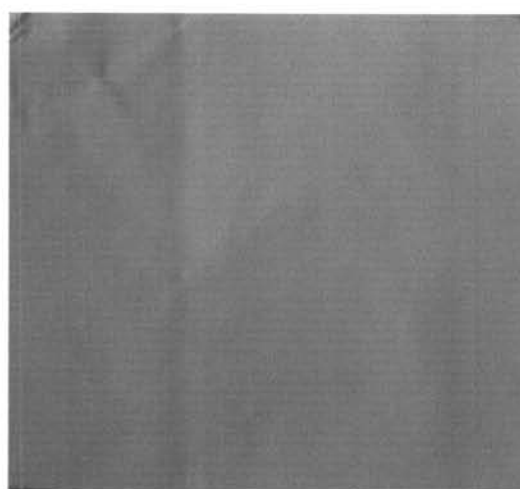
c) 0.6%Ti, 2.5% chitosan

d) 0.8%Ti, 2.5% chitosan

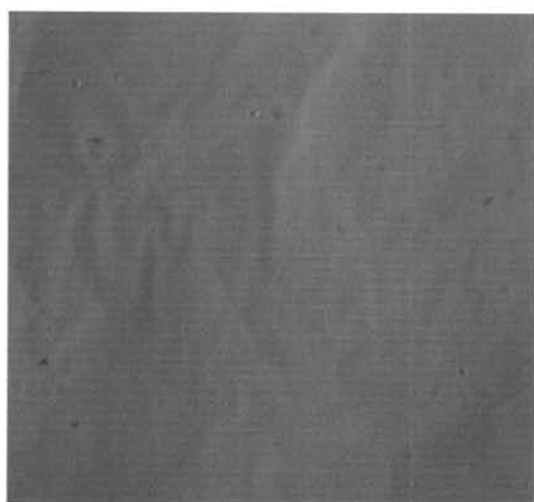
Figure 4.17 Photographs of TiO_2 /chitosan film that prepared from 2.5% chitosan with variation of Ti contents



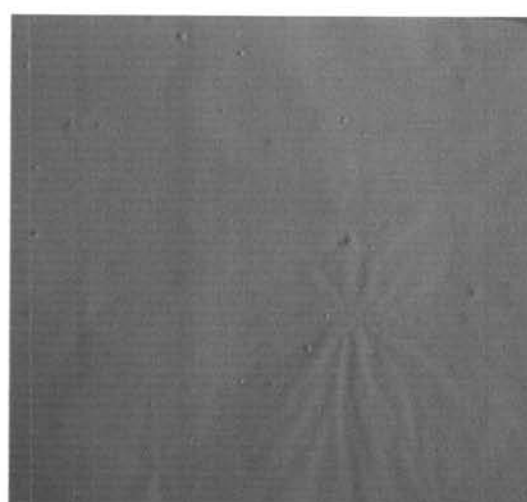
a) 0.2%Ti, 2.0% chitosan



b) 0.4%Ti, 2.0% chitosan

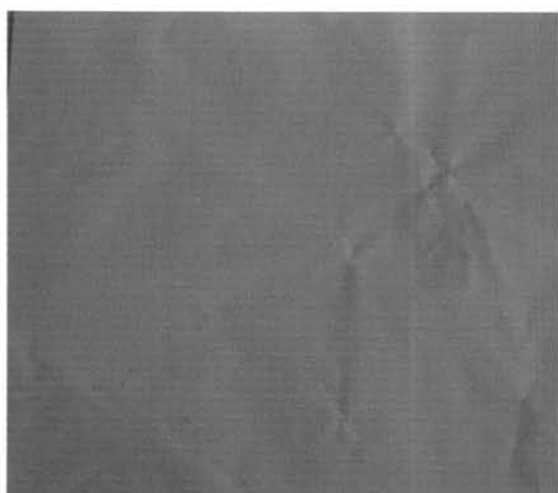


c) 0.6%Ti, 2.0% chitosan

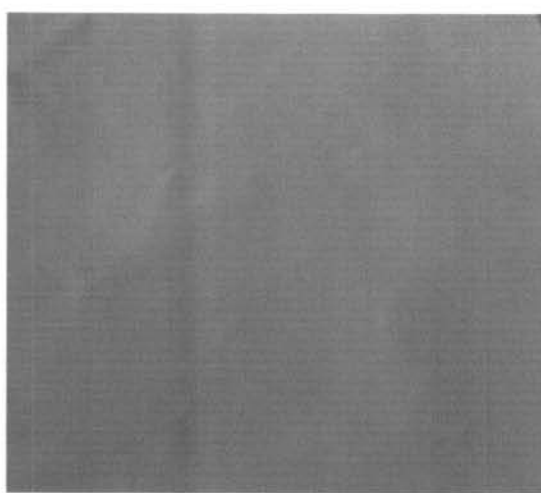


c) 0.8%Ti, 2.0% chitosan

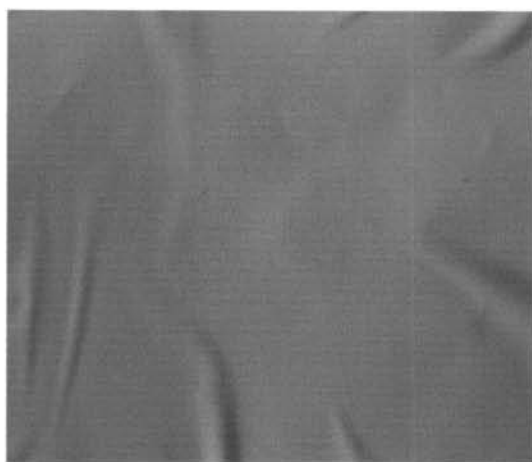
Figure 4.18 Photographs of TiO₂/chitosan film that prepared from 2.0% chitosan with variation of Ti contents



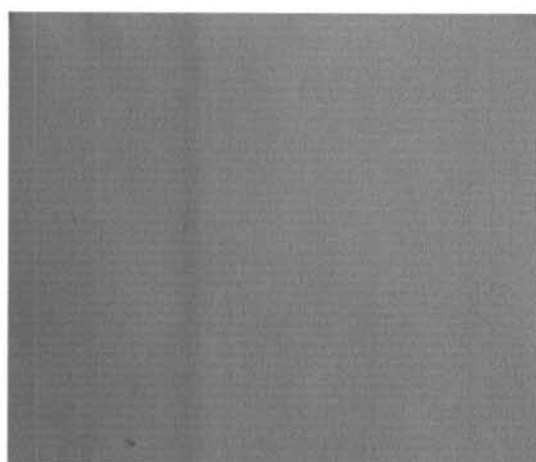
a) 0.2%Ti,1.5% chitosan



b) 0.4%Ti,1.5% chitosan



c) 0.6%Ti,1.5%chitosan



d) 0.8%Ti,1.5%chitosan

Figure 4.19 Photographs of TiO_2 /chitosan film that prepared from 1.5% chitosan with variation of Ti contents

Therefore, in this experiment, TiO_2 /chitosan films were prepared from 1.5% chitosan in variation of Ti contents to investigate the effects of titanium quantity on film properties, adsorption and photocatalytic activity for chromium (IV) removal.

4.2.1 Results of film weight, thickness and characteristic in variation of Ti contents

Effect of chitosan content on properties of film show in table 4.17– 4.19 so, Ti content was important factor that influence on chitosan and TiO₂/chitosan film properties such as weight, thickness and characteristics of film.

Weight of film result represent in table 4.17. In this study, the weight of TiO₂/chitosan film that prepared from 0.2, 0.4, 0.6 and 0.8 % w/w of Ti with 1.5% chitosan was obtained in ranged of 0.0982-0.1489 g S.D. \pm 0.019 whereas weight of chitosan dry film(0%Ti,1.5% chitosan) was 0.0800 g S.D. \pm 0.0012. This result could be compared between TiO₂/chitosan and chitosan films weight, and it was found that weight of TiO₂/chitosan film was heavier than weight of chitosan film because of addition of TiO₂ on TiO₂/chitosan film. When consideration about relation between films which prepared in variation of Ti contents, the result shown that trend of film weight of all samples were increased with increasing of Ti content and the weight of film that prepared from 0.8% chitosan was the heaviest weight.

Regarding film thickness (Table 4.18), thickness of TiO₂/chitosan film was obtained in ranged of 0.029-0.052 mm S.D. \pm 0.010 while the thickness of chitosan film (0%Ti,1.5% chitosan) was 0.021 mm S.D. \pm 0.004 . When compared between Ti content on film was found that the thickness of film that prepared from 0.8% Ti was the thickest. All samples, thickness of film trend to increase with increasing of Ti content.

From this result, it could be concluded that the relation between Ti content with weight and thickness of film, its weight and thickness tended to increase with the increasing in Ti content.

The properties of prepared TiO₂/chitosan and chitosan films such as coarseness, transparent and acid odor of film were observed. The physical properties of film show in table 4.19. The film surface that exposed to the air was coarse, while the reverse surface touching glass was smooth and there were no acid odor after dry in room temperature and the transparent of film were observed. Chitosan films were

transparent films which look like clear plastic on the other hand TiO₂/chitosan films look like dense plastic.

Table 4.17 Weight of films that prepared from 0, 0.2, 0.4, 0.6 and 0.8 % Ti with 1.5 % chitosan

Types of film	Chitosan contents (%)	Ti contents (%)	Weigh of film (g)					Average (g)	SD
TiO ₂ /chitosan film	1.5	0.2	0.1010	0.0888	0.1006	0.0999	0.1007	0.0982	0.0053
	1.5	0.4	0.1181	0.1134	0.1145	0.1132	0.1114	0.1141	0.0025
	1.5	0.6	0.1290	0.1286	0.1301	0.1306	0.1285	0.1291	0.0009
	1.5	0.8	0.1455	0.1478	0.1571	0.1500	0.1441	0.1498	0.0020
Chitosan film	1.5	0	0.0781	0.0811	0.0801	0.0800	0.0810	0.0800	0.0012

Table 4.18 Thickness of films that prepared from 0, 0.2, 0.4, 0.6 and 0.8 % Ti with 1.5 % chitosan

Types of film	Chitosan contents (%)	Ti contents (%)	Thickness of film (mm)					Average (mm)	SD
TiO ₂ /chitosan film	1.5	0.2	0.030	0.025	0.030	0.035	0.025	0.029	0.004
	1.5	0.4	0.043	0.035	0.030	0.030	0.045	0.037	0.005
	1.5	0.6	0.050	0.045	0.040	0.050	0.045	0.046	0.004
	1.5	0.8	0.055	0.050	0.050	0.050	0.055	0.052	0.003
Chitosan film	1.5	0	0.025	0.020	0.020	0.025	0.015	0.021	0.004

Table 4.19 Physical characteristics of film that prepared from 0, 0.2, 0.4, 0.6 and 0.8 % Ti with 1.5 % chitosan

Types of film	Chitosan contents (%)	Ti contents (%)	Weight of slurry (g)	characteristics			
				Transparency	Acid smell	Coarseness of film surface	
						Exposed air	Contacting glass plate
TiO ₂ /chitosan film	1	0.4	5	X	X	O	X
	1.5	0.4	5	X	X	O	X
	2	0.4	5	X	X	O	X
	2.5	0.4	5	X	X	O	X
Chitosan film	1.5	-	5	O	X	O	X

O = Showing characteristic

X = Not showing characteristic

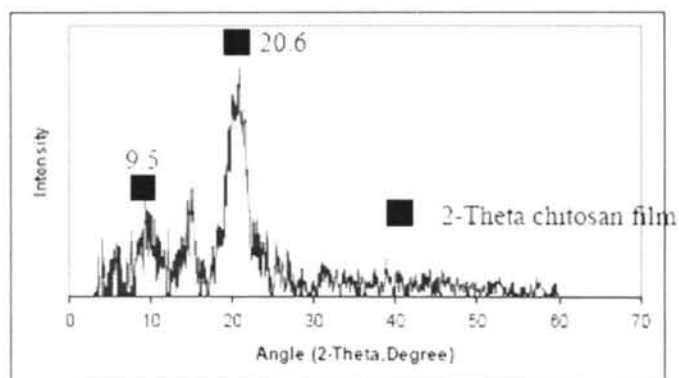
4.2.2 Crystal structures of TiO₂/chitosan and chitosan films

XRD pattern of TiO₂ powder represent in figure 4.3 (a). TiO₂ crystalline was mainly composed of anatase phase as shown by the main peak of 2- Theta at 25.3 degree was anatase phase for 2- Theta at 27.5 degree was rutile phase.

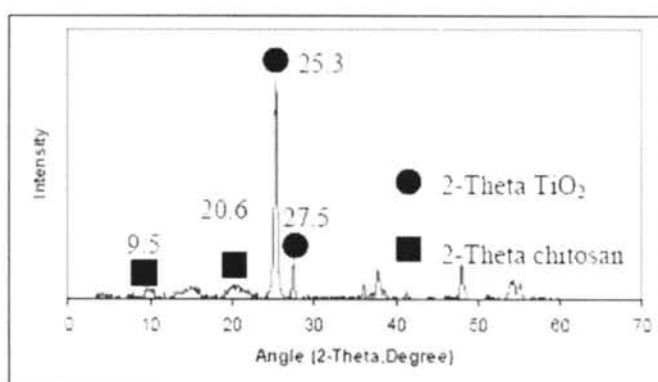
Crystallizations of TiO₂/chitosan (0.8% Ti, 1.5% chitosan) and chitosan film(0% Ti, 1.5% chitosan) was checked with Power X-Ray Diffractometer (XRD). Chitosan film was outstanding demonstrated peaks of 2- Theta in three positions which were at 9.5, 15.5 and 20.5 degree (Figure 4.20). So The 2- Theta at 9.5 and 20.5 degree were amino acid structure position which was a agile group to react with chitosan reaction and 15 degree was a water crystallize structure (Wanichpongpan, 2002).

In the other hand TiO₂/chitosan film was shown peak of 2-Theta at 9.5, 15.5, 20.5, 25.3 and 27.5 degree. The 2- Theta at 9,15.5and 19 degree which were the same peak position as chitosan and for 25.3 degree was anatase phase and 27.5 degree was rutile phase.

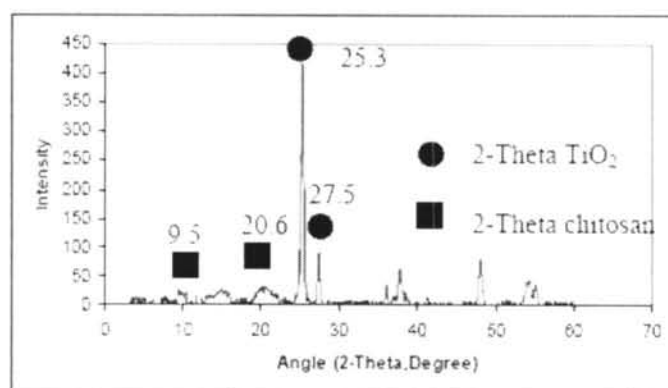
From XRD spectra, its result could be confirmed that chitosan and TiO₂/chitosan films in this study had no change in identity of chitosan and TiO₂ because chitosan and TiO₂ patterns were same pattern as chitosan and TiO₂/chitosan films (Figure 4.21).



a) Chitosan film(1.5%chitosan,0%Ti)



b) TiO_2 chitosan films(1.5%chitosan,0.2%Ti)



c) TiO_2 chitosan films(1.5%chitosan,0.8%Ti)

Figure 4.20 X-ray diffraction patterns of a) Chitosan film and b) TiO_2 /chitosan films (1.5%chitosan,0.2%Ti) and c) TiO_2 /chitosan films(1.5%chitosan,0.8%Ti)

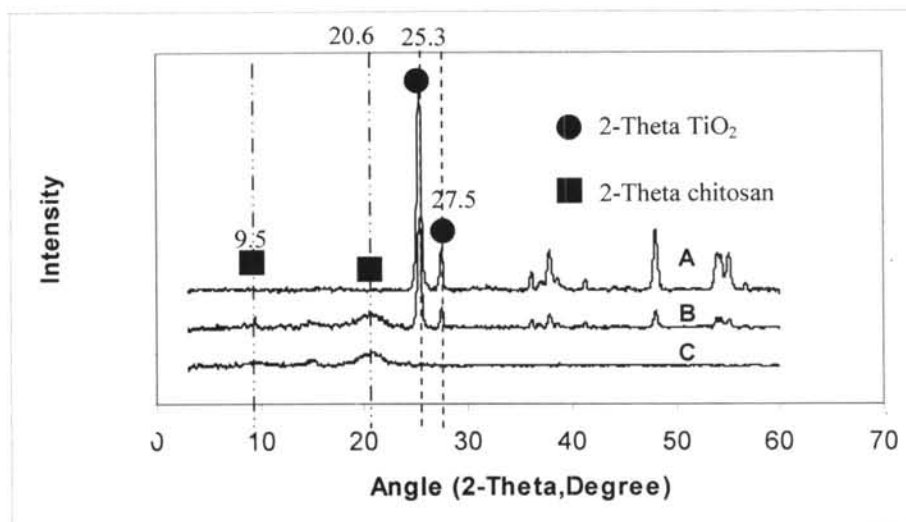
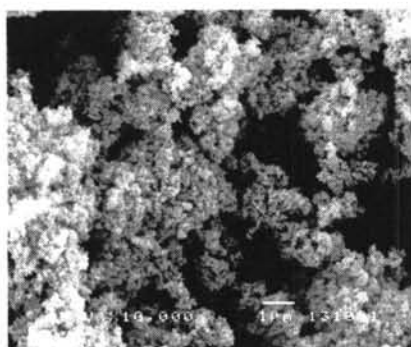
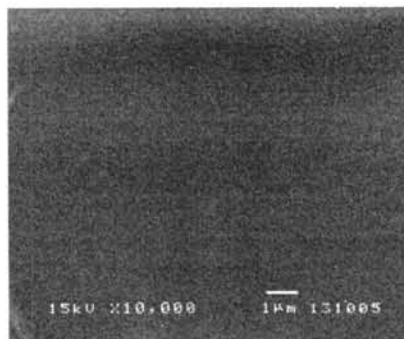


Figure 4.21 X-ray diffraction patterns of the comparison between TiO_2 powder (A) and TiO_2 /chitosan film (B) and chitosan film (C)

4.2.3 Surface morphology of TiO_2 /chitosan and chitosan films analyzed by SEM

In this study, TiO_2 powder, TiO_2 /chitosan and chitosan films were analyzed by using Scanning Electron Microscope (SEM) which was used at 10000 times in order to see surface morphology (Figure 4.22). Results of this study shown that TiO_2 powder was agglomerated as particle. For chitosan film, the surface was flat and smooth which shows that chitosan was a homogeneous film before using for chromium (VI) removal. When TiO_2 composed with chitosan (TiO_2 /chitosan film) which found that TiO_2 particles were non-uniform scattered into chitosan. In this study, one condition of TiO_2 /chitosan film has been shown since surface morphology of chitosan and TiO_2 /chitosan film that prepared from variation of chitosan contents have no different in surface morphology.

a) TiO₂ powder

b) Chitosan film (1.5% chitosan, 0%Ti)

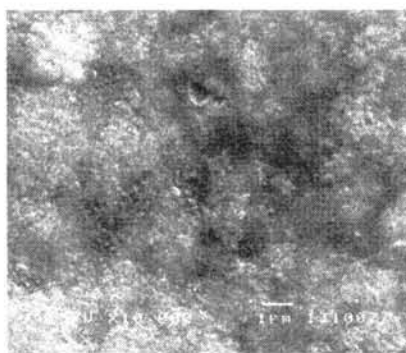
c) TiO₂/chitosan film (1.5% chitosan, 0.4%Ti)

Figure 4.22 Scanning electron micrographs of a) TiO₂ powder, b) Chitosan film and c) TiO₂/chitosan film

4.2.4 Treating of chromium (IV) using synthesized TiO₂/chitosan and chitosan films

Figure 4.23 show about TiO₂ powder, TiO₂/chitosan and chitosan films in different TiO₂ quantities for removing 100 mg/L chromium (VI) concentration. This experiment was divided in two processes which were adsorption and photocatalytic processes. At the end of photocatalytic process, the result shown that chromium removal efficiency of TiO₂/chitosan film was higher than chromium removal efficiency of TiO₂ powder. The explanation of this result might become TiO₂ is as catalytic in photocatalytic process which were low adsorption activity in photocatalysis process. While TiO₂/chitosan film was combined with chitosan that is a powerful chelating agent, which is easy to form complexes with chromium(VI)

(Ramnani et al.,2005).Therefore, the adsorption ability of TiO_2 would be enhanced by composed with chitosan.

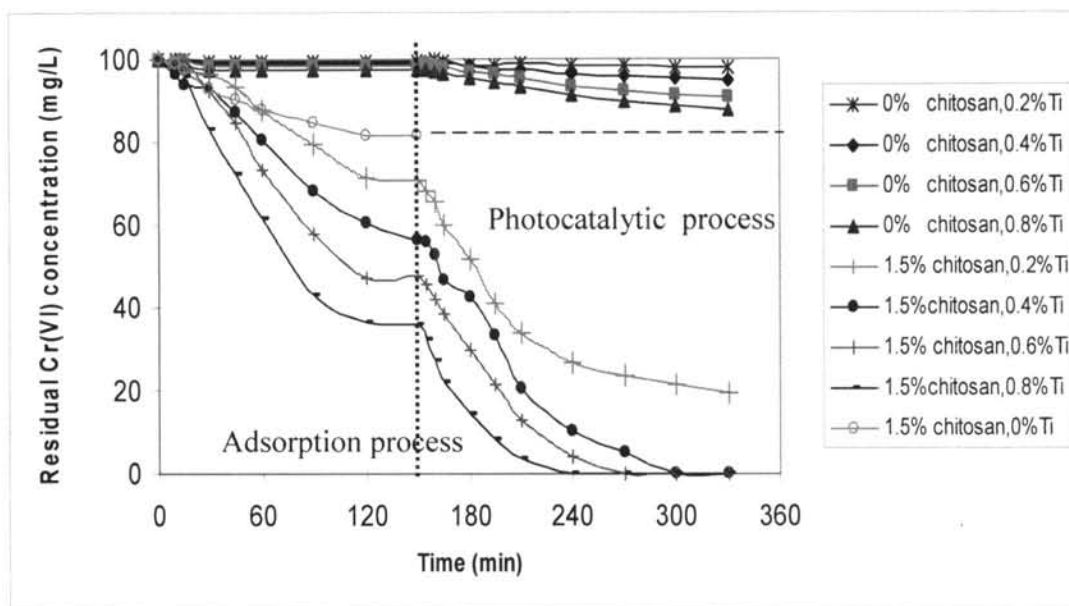


Figure 4.23 Removal of 100 mg/L chromium (IV) concentration using synthesized TiO_2 /chitosan, chitosan film and TiO_2 powder in adsorption and photocatalytic processes.

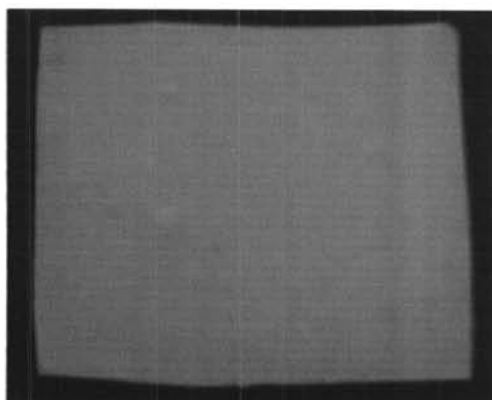
Table 4.20 shows about TiO_2 /chitosan, chitosan film and TiO_2 powder for removing 100 mg/L chromium(VI) concentration. It was obvious that with TiO_2 powder alone (0% chitosan with 0.2, 0.4 0.6 and 0.8 % Ti), the removal efficiency is only 2.25, 5.08, 9.01 and 12.53%, respectively. In addition, using chitosan only the highest efficiency was 18.65 % with the 1.5 % chitosan content (without Ti). TiO_2 /chitosan film that prepared from 1.5% chitosan with 0.8 % Ti could completely remove 100 mg/L chromium(VI) concentration. It was clearly seen that the film with 1.5% chitosan, 0.8% Ti provided the performance (100% chromium(VI) removal) with the shortest treatment period.

Table 4.20 Percentage removals of 100 mg/L chromium(VI) by using synthesized films that prepared from 0, 0.2, 0.4, 0.6 and 0.8% Ti with 1.5 % chitosan and TiO₂ powder in adsorption and photocatalytic processes

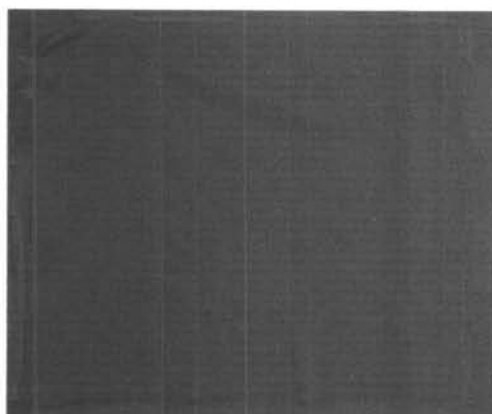
Types of film	Chitosan content (%)	Ti content (%)	Initial concentration of chromium(VI) (mg/L)	% Removal at the end of adsorption process	% Removal at the end of photocatalytic process
TiO ₂ /chitosan film	1.5	0.2	100	29.01	81.28
	1.5	0.4	100	43.36	100.00
	1.5	0.6	100	54.35	100.00
	1.5	0.8	100	64.05	100.00
TiO ₂ powder	0	0.2	100	0.33	2.25
	0	0.4	100	0.84	5.08
	0	0.6	100	1.40	9.01
	0	0.8	100	2.38	12.53
Chitosan films	1.5	0	100	18.64	-

4.2.4.1 Determination of adsorption isotherm of TiO₂ /chitosan films in different Ti contents.

Table 4.21 demonstrates the adsorption of 100 mg/L of chromium(VI) concentration on TiO₂/chitosan, chitosan film and TiO₂ powder surface. Comparison between TiO₂ powder, TiO₂/chitosan film (varied Ti content and fixed 1.5% chitosan) could be removed chromium (VI) in range 29.01% - 64.50% whereas TiO₂ powder could only remove in range 0.33-2.38 % and chitosan film(0%Ti,1.5% chitosan) could remove 18.64 %. Chromium(VI) removal efficiency of TiO₂/chitosan film was higher than chitosan film and TiO₂ powder. For TiO₂/chitosan film was prepared in different Ti contents the result shown that 0.8%Ti with 1.5% chitosan provided the highest efficiency for chromium(VI) removal and lower chromium(VI) efficiency were 0.6, 0.4and 0.2% Ti, respectively.



a) TiO_2 /chitosan film before treating of chromium(VI)



b) TiO_2 /chitosan film at the end of adsorption process



c) TiO_2 /chitosan film at the end of photocatalytic process

Figure 4.24 Photographs of TiO_2 /chitosan films in different conditions

Table 4.21 Percentage removals of 100 mg/L chromium(VI) by using synthesized films that prepared from 0, 0.2, 0.4, 0.6 and 0.8% Ti with 1.5 % chitosan and TiO₂ powder in adsorption process

Types of film	Chitosan contents (%)	Ti contents (%)	Initial concentration of chromium(VI) (mg/L)	x/m at the end of adsorption process (mg of Cr(VI)/g of film)	% Removal
TiO ₂ /chitosan film	1.5	0.2	100	304.05	29.01
	1.5	0.4	100	420.12	43.36
	1.5	0.6	100	430.85	54.35
	1.5	0.8	100	433.23	64.05
TiO ₂ powder	0	0.2	100	21.25	0.33
	0	0.4	100	28.72	0.84
	0	0.6	100	30.83	1.40
	0	0.8	100	37.72	2.38
Chitosan film	1.5	0	100	252.23	18.64

The results depicted in figure 4.25, the equilibration time for the physico-chemical reaction between chromium(VI) and TiO₂/chitosan films in each condition at pH 3. As seen from the graph, adsorption of chromium(VI) and TiO₂/chitosan films surface occurred during the equilibration period. The amount of chromium(VI) adsorbed was increased with time and attains equilibrium within 120 min. This indicates the equilibration time required for maximum chromium(VI) adsorption on TiO₂/chitosan film surface.

From figure 4.24 shows that the chitosan color was white color. After adsorption process chitosan color has changed from white to yellow. It was demonstrated that chromium(VI) has adsorbed on TiO₂/chitosan. When photocatalytic process has been finished chitosan film color and turn in light-green color which shown that chromium(VI) has fixed on TiO₂/chitosan and change from chromium(VI) to chromium(III).

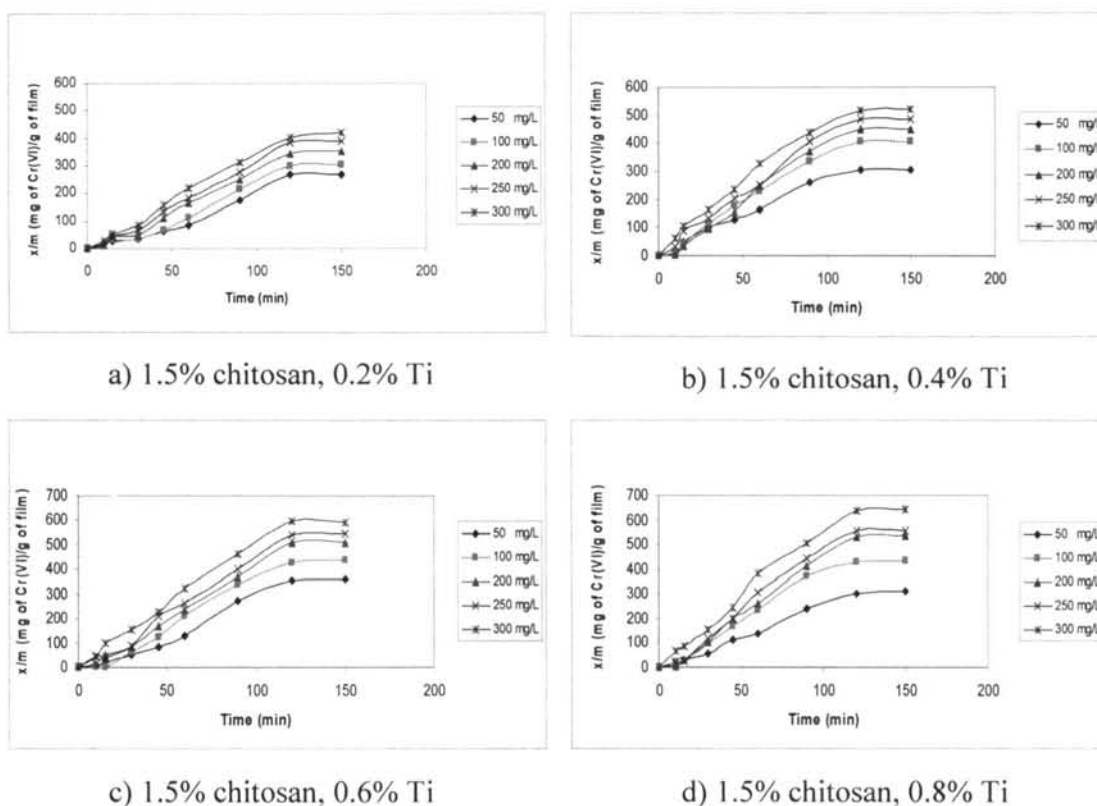


Figure 4.25 Adsorption of chromium(VI) on TiO_2 /chitosan film that prepared from a) 1.5% chitosan, 0.2% Ti, b) 1.5% chitosan, 0.4% Ti, c) 1.5% chitosan, 0.6% Ti and d) 1.5% chitosan, 0.8% Ti in different initial concentrations of chromium(VI)

Langmuir equation was applied for adsorption equilibrium of chromium(VI) onto TiO_2 /chitosan film surfaces. The Langmuir adsorption isotherm was based on these assumptions: (i) maximum adsorption corresponds to a saturated monolayer of adsorbate molecules on the adsorbent surface: (ii) the energy of adsorption is constant: and (iii) there is no transmigration of adsorbate in surface plane. The Langmuir equation was shown below:

$$C_e / (x/m) = 1/(Q_o b) + C_e / Q_o \quad (\text{Eq. 4.13})$$

Where C_e is the equilibrium concentration of chromium(VI), mg/L, x/m is the amount of adsorbed chromium(VI) at equilibrium per unit mass of TiO_2 /chitosan film, mg/g, Q_o is the maximum adsorption at monolayer coverage, mg/g and b is Langmuir constant related to the

affinity of binding sites, L/mg and it is a measure of the energy of adsorption. The linear plot of $C_e/(x/m)$ vs C_e in figure 4.26 shown that adsorption of chromium(VI) onto the TiO₂/chitosan film surface in each condition obeys Langmuir adsorption isotherm. The correlation coefficient for the linear regression fit of Langmuir plot and expressed equation present in table 4.24

The essential characteristic of the Langmuir isotherm can be expressed in term of a dimensionless constant separation factor or equilibrium parameter, R_L , which is defined by (Mackay et al., 1982)

$$R_L = 1/(1 + bC_o) \quad (\text{Eq. 4.14})$$

Where b is the Langmuir constant, and C_o is the initial concentration of Chromium(VI). The parameter indicates the adsorption isotherm show in table 4.7. The values of R_L in this experiment set were calculated (Table 4.22) and it was found that all R_L values were between 0 and 1, indicating favorable chromium(VI) adsorption onto each TiO₂/chitosan film surface.

Figure 4.27 shows about the relation between Q_0 (the maximum adsorption at monolayer coverage, mg of chromium /g of film) and chitosan content which shown that maximum adsorption at monolayer coverage was increased with increasing of Ti content on TiO₂/chitosan film. Figure 4.28 shows about the relation between b which is a measure of the energy of adsorption.(L/mg) and chitosan content found that measure of the energy of adsorption was increased with the increasing of Ti content on TiO₂ chitosan film. From this result could be concluded that the relation between Ti content with Q_0 and b tended to increased with increasing in Ti content. The Langmuir constants, Q_0 and b values were determined form the Langmuir plotsshow in table 4.24.

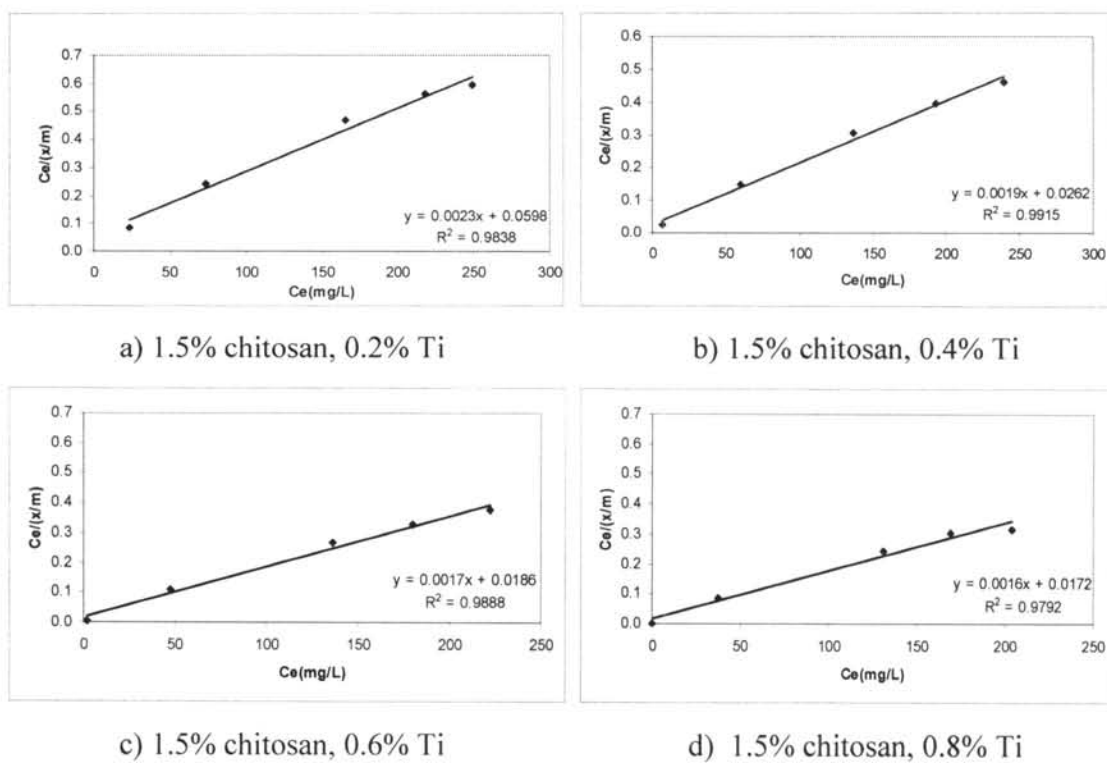


Figure 4.26 Langmuir adsorption isotherm plot for adsorption of chromium(VI) on TiO_2 /chitosan film that prepared from a) 1.5% chitosan, 0.2% Ti, b) 1.5% chitosan, 0.4% Ti, c) 1.5% chitosan, 0.6%Ti and d) 1.5% chitosan, 0.8% Ti

Table 4.22 R_L Values for Langmuir adsorption isotherm for TiO_2 /chitosan films in different Ti contents

Initial concentrations of chromium(VI) (mg/L)	R_L Value of TiO_2 /chitosan film (1.5%chitosan, 0.2%Ti)	R_L Value of TiO_2 /chitosan film (1.5%chitosan, 0.4%Ti)	R_L Value of TiO_2 /chitosan film (1.5%chitosan, 0.6%Ti)	R_L Value of TiO_2 /chitosan film (1.5%chitosan, 0.8%Ti)
50	0.342	0.256	0.197	0.177
100	0.206	0.147	0.109	0.097
200	0.115	0.079	0.058	0.051
250	0.094	0.064	0.047	0.041
300	0.080	0.054	0.039	0.035

Table 4.23 Langmuir and Freundlich adsorption isotherms for TiO₂/chitosan film that prepared from 0.2, 0.4, 0.6 and 0.8% Ti with 1.5 % chitosan

Adsorption Isotherms	Chitosan contents (%)	Ti contents (%)	Equations	R ²
Langmuir	1.5	0.2	$C_e/(x/m) = 0.0023 C_e + 0.0598$	0.9838
	1.5	0.4	$C_e/(x/m) = 0.0018 C_e + 0.0310$	0.9824
	1.5	0.6	$C_e/(x/m) = 0.0017 C_e + 0.0209$	0.9872
	1.5	0.8	$C_e/(x/m) = 0.0016 C_e + 0.0172$	0.9792
Freundlich	1.5	0.2	$\log(x/m) = 0.1794 C_e + 2.1685$	0.9373
	1.5	0.4	$\log(x/m) = 0.1403 C_e + 2.383$	0.9352
	1.5	0.6	$\log(x/m) = 0.0992 C_e + 2.5066$	0.8725
	1.5	0.8	$\log(x/m) = 0.0923 C_e + 2.5445$	0.9039

Table 4.24 Q_0 and b values for Langmuir adsorption isotherm for TiO₂/chitosan film that prepared from 0.2, 0.4, 0.6 and 0.8% Ti with 1.5 % chitosan

Isotherm	Chitosan contents (%)	Ti contents (%)	Q_0 (mg/g)	b (L/mg)
Langmuir	1.5	0.2	434	0.038
	1.5	0.4	555	0.058
	1.5	0.6	588	0.081
	1.5	0.8	625	0.093

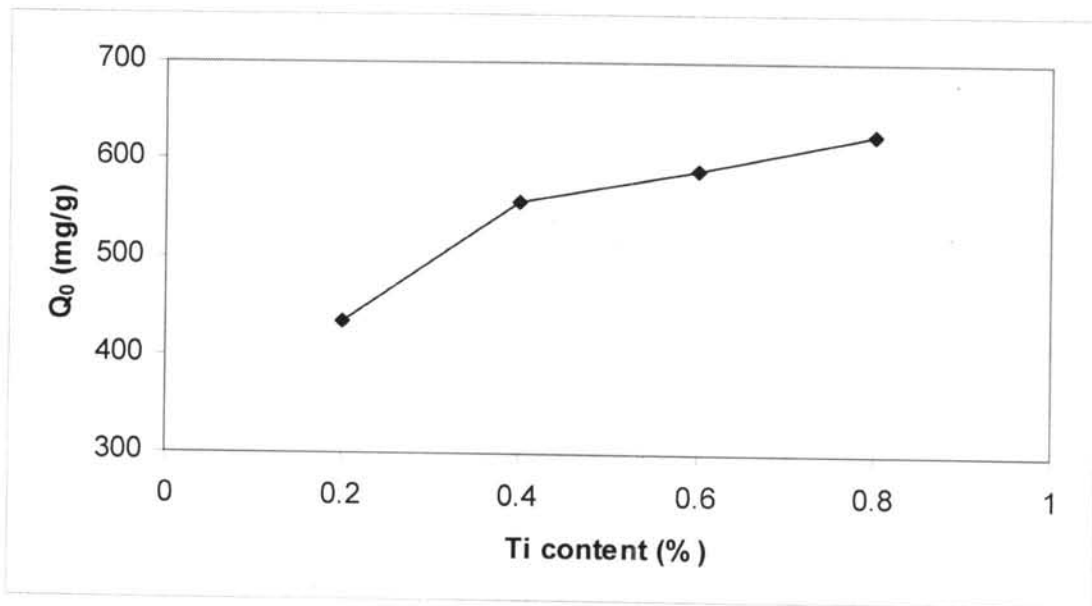


Figure 4.27 Plotting of relation between Q_0 and Ti contents

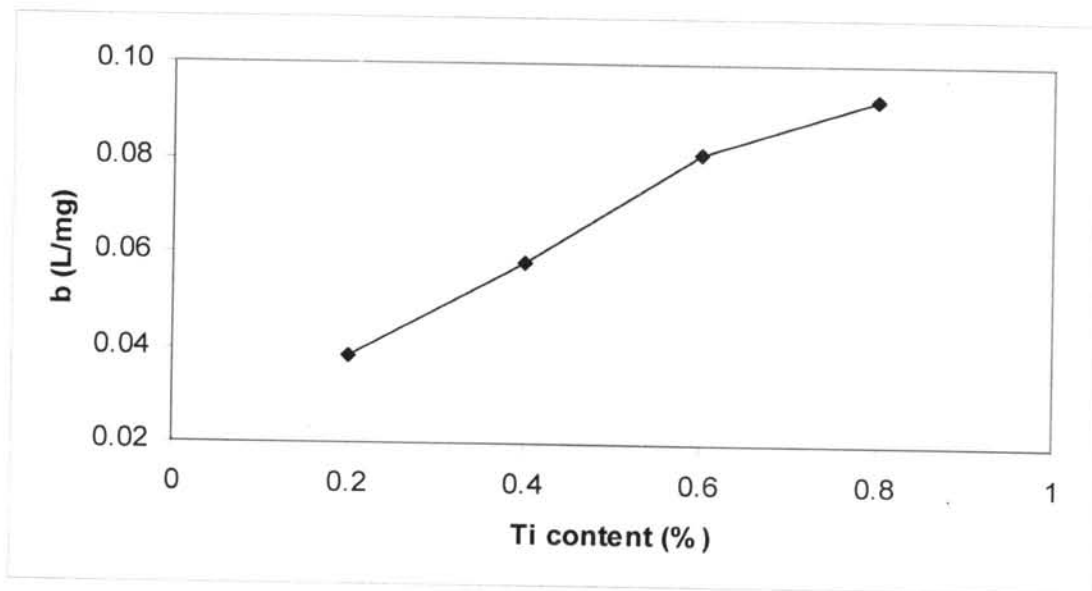


Figure 4.28 Plotting of relation between b and Ti contents

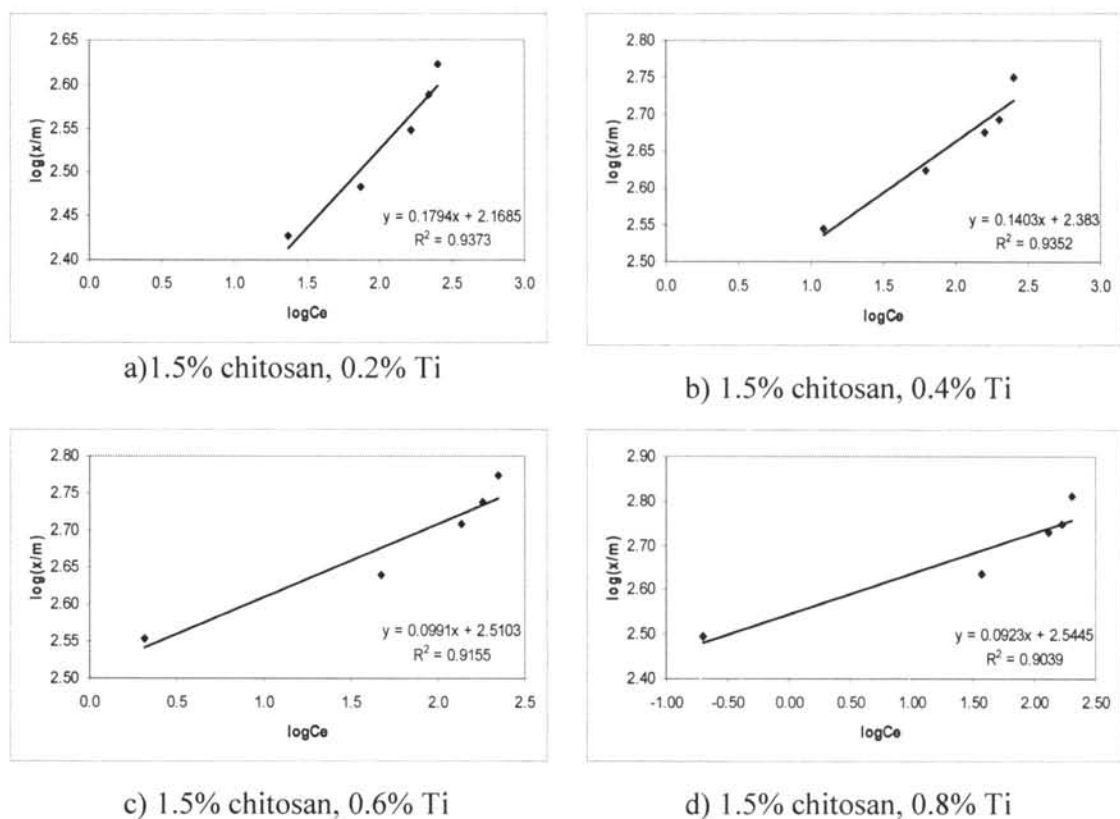


Figure 4.29 Freundlich adsorption isotherm plot for adsorption of chromium(VI) on TiO_2 /chitosan film that prepared from a) 1.5% chitosan, 0.2% Ti, b) 1.5% chitosan, 0.4% Ti, c) 1.5% chitosan, 0.6% and d) 1.5% chitosan, 0.8% Ti

Freundlich equation was also applied to adsorption of chromium(VI) onto TiO_2 /chitosan film surface. The Freundlich equation is basically empirical, and generally agrees with experimental data over a moderate range of adsorbate concentrations. The Freundlich isotherm is represented by the equation (Mckay et al., 1982)

$$\text{Log}(x/m) = (1/n)\log C_e + \log k_f \quad (\text{Eq. 4.15})$$

Where C_e is the equilibrium concentration of chromium(VI), mg/L, x/m is the amount of adsorbed chromium(VI) at equilibrium per unit mass of TiO₂/chitosan film, mg/g, k_f and n are the Freundlich constants. The plotting of $\log(x/m)$ versus $\log C_e$ based on equation was shown above for the same experimental results in figure. 4.29. The correlation coefficient for the linear regression fit of the Freundlich plot and the expressed equation were presented in table 4.23.

The correlation coefficient for linear regression fit of Langmuir plot in each condition of TiO₂/chitosan film (0.2, 0.4, 0.6 and 0.8% Ti with 1.5 % chitosan) was found to be 0.9838, 0.9824, 0.9872 and 0.9792 while the correlation coefficient for the Freundlich plot in each condition of TiO₂/chitosan film (0.2, 0.4, 0.6 and 0.8% Ti with 1.5 % chitosan) were found to 0.9373, 0.9352, 0.8725 and 0.9039, respectively which were less than that from Langmuir plot. The value of correlation coefficient of chromium(VI) adsorption indicates that adsorption behavior of chromium(VI) onto TiO₂/chitosan film tends to be a monolayer adsorption as described by Langmuir isotherm rather than Freundlich isotherms.

4.2.4.2 Determination of kinetic values in photocatalytic reduction of chromium(VI) using TiO₂/chitosan films in variation of Ti contents.

The photocatalytic reductions of chromium (VI) with TiO₂/chitosan film that prepared from 0.2, 0.4, 0.6 and 0.8% Ti with 1.5% chitosan in variation of initial concentrations of chromium (VI) in the range of 50 – 300 mg/L were conducted. The results of this experimental part were shown about residual fraction of chromium (VI) (Figure 4.31). It was obvious that the efficiency in chromium (VI) removal decrease with increasing of initial concentration of chromium (VI) in solution. To explain the behavior of photocatalytic reduction of chromium (VI) by synthesized TiO₂/chitosan film for each condition in term of kinetic study, two patterns of kinetic orders, which were zero-order and pseudo-first order equations which were considered. As seen in chromium (VI) declining pattern, the kinetic order to explain the existed reaction can be either zero order or pseudo first order.

Value of k_{obs} of zero-order pattern was determined from the slope of graph which was plot between $C-C_o$ and reaction time, t . The R^2 values for linear regression was calculated to exhibit the tendency of the reaction pattern to be describe as a zero-order pattern.

While value of k_{obs} from pseudo-first order was determined from slope of graph which was plot between $-\ln(C/C_o)$ and reaction time, t (Figure 4.32). The R^2 values for linear regression was calculated to exhibit the tendency of the reaction pattern to be described as pseudo-first order. Values of k_{obs} from pseudo-first order equation were determined as show in table 4.25-4.28.

The photocatalytic reduction of 100 mg/L chromium (VI) concentration under irradiation process for TiO_2 /chitosan film with different Ti contents and TiO_2 powder were compared. The ratio of residual to initial concentration of chromium(VI) in term of C/C_o as a function of irradiation time which illustrate in figure 4.30. It was obvioued that TiO_2 /chitosan film provided the higher efficiency in chromium(VI) removal than TiO_2 powder. This explanation might come from the fact that chitosan that composed with TiO_2 could enhance adsorption ability of TiO_2 /chitosan film in photocatalytic process. Chitosan is biopolymer material produced from N- deacetylation of chitin which has superb ability in adsorption pollutants especially metal ions (Ramnani et al.,2005). In consideration of treating efficiency of chromium(VI) using different chitosan contents that prepared from 0.2, 0.4, 0.6 and 0.8% Ti with 1.5% chitosan. The result shown that 0.8 % Ti was the highest efficiency for chromium (VI) removal and lower chromium (VI) efficiency is 0.6, 0.4 and 0.2% Ti, respectively.

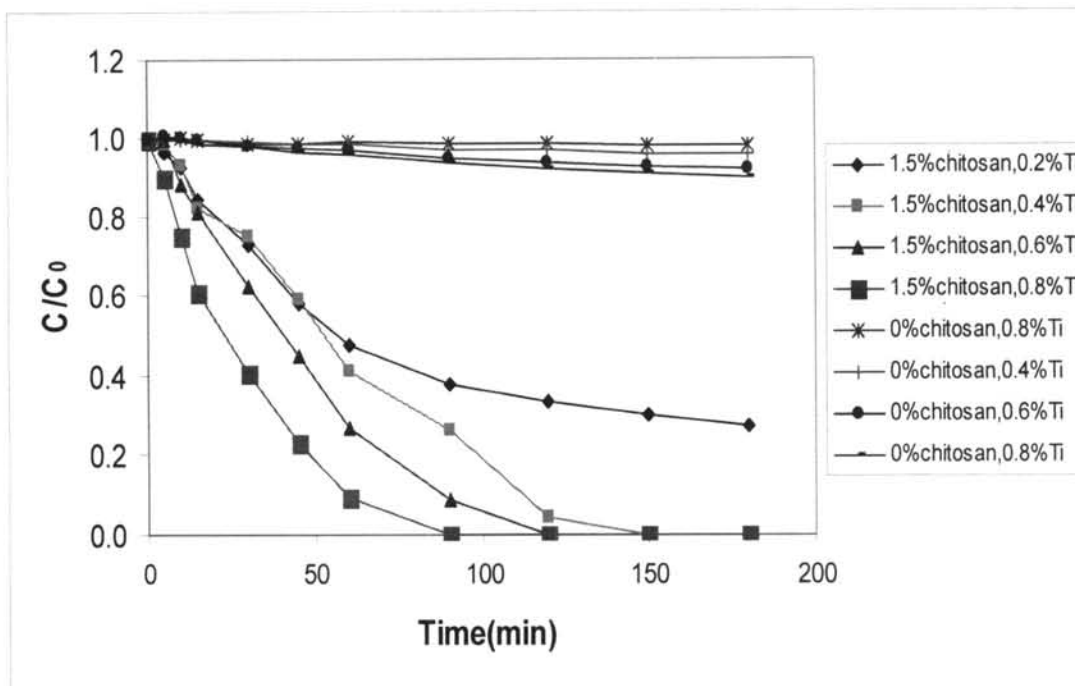


Figure 4.30 Residual fraction of 100 mg/L chromium (VI) in different Ti contents on TiO_2 /chitosan film

Considering the pattern of kinetic equation, the photocatalytic reduction reactions of TiO_2 /chitosan films in different Ti contents could be represented by pseudo-first order pattern for initial chromium(VI) concentration in range of 50-300 mg/L because the correlation coefficients (R^2) value of zero order is less than that correlation coefficients value from pseudo-first order. The rate constant for photocatalytic process in 50 mg/L chromium(VI) concentration that was removed by TiO_2 /chitosan film prepared from 1.5% chitosan with 0.8% Ti could not be determined because at the end of the adsorption process, the residual chromium concentration was equal to zero.

The photocatalytic reduction reactions of TiO_2 /chitosan films in different Ti contents are the best described by pseudo-first order pattern. As chromium(VI) concentration increased with fixed dosage of TiO_2 /chitosan film in the system, the reaction become depended on both concentration of chromium(VI) and reaction time.

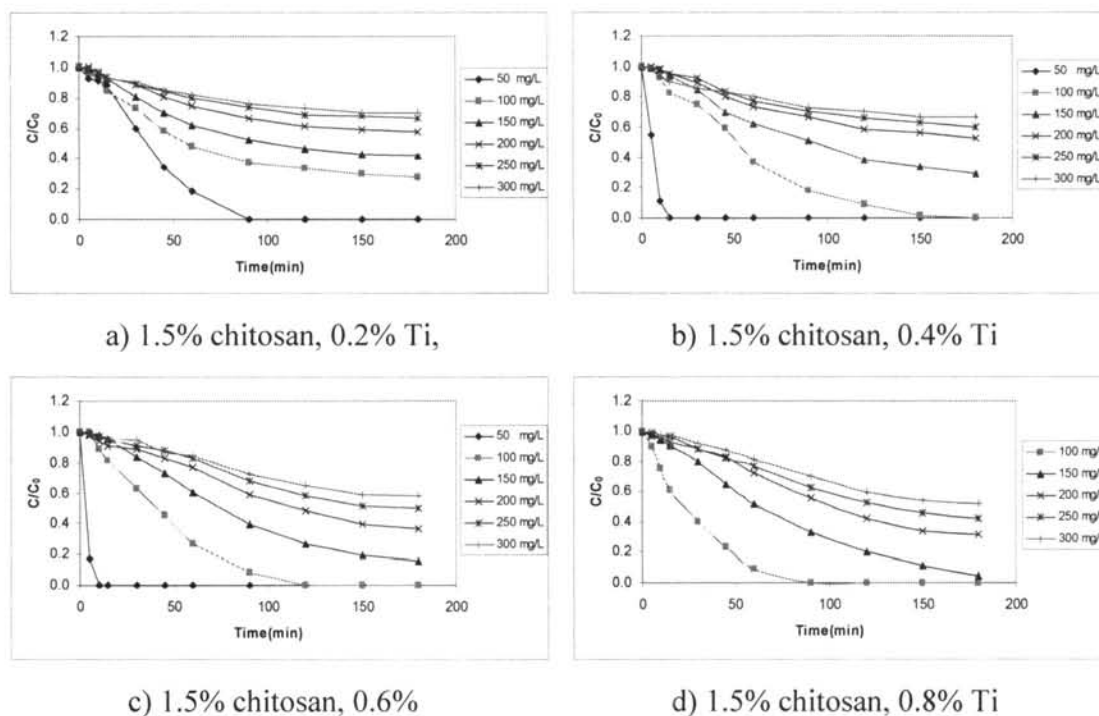


Figure 4.31 Residual fraction of chromium (VI) in different initial concentrations for TiO_2 /chitosan film that prepared from a) 1.5% chitosan, 0.2% Ti, b) 1.5% chitosan, 0.4% Ti, c) 1.5% chitosan, 0.6% Ti, d) 1.5% chitosan, 0.8% Ti

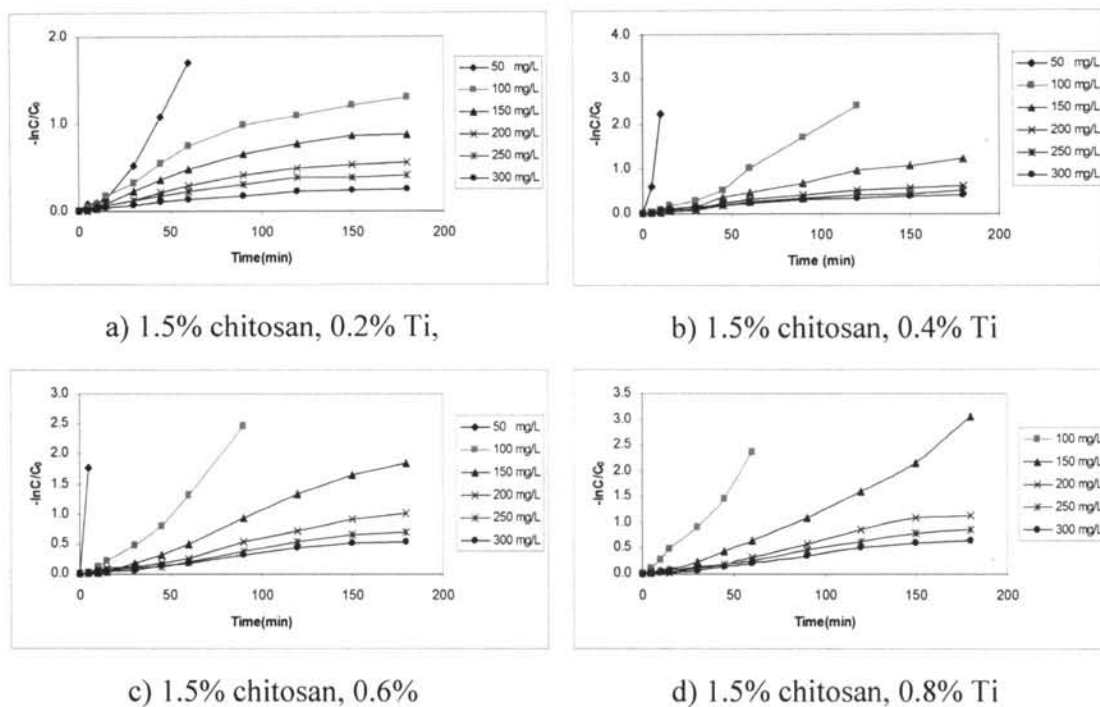


Figure 4.32 Relation between $-\ln(C/C_0)$ and time in different of chromium(VI) initial concentrations for TiO_2 /chitosan film that prepared from a) 1.5% chitosan, 0.2% Ti, b) 1.5% chitosan, 0.4% Ti, c) 1.5% chitosan, 0.6% Ti and d) 1.5% chitosan, 0.8% Ti

The plotting of k_{obs} as a function of Ti content on TiO_2 /chitosan film from each condition and TiO_2 powder that used for removed 100 mg/L chromium(VI) concentration which show in figure 4.33. This figure shows that k_{obs} obtained from TiO_2 /chitosan film provided higher than k_{obs} from TiO_2 powder. While the k_{obs} value tendency of TiO_2 /chitosan film was increased when increased Ti content and k_{obs} from TiO_2 /chitosan film prepared from 0.8%Ti with 1.5% chitosan was the highest (0.0358 min^{-1}) because in this film composed with maximum TiO_2 quantity which implied that the film also composed with maximum titanium in anatase phase. In this experiment, TiO_2 powder were commercial media which had highly anatase intensity, so this information was related with TiO_2 powder XRD pattern that outstanding demonstrated peak of 2-Theta in position 25.3 degree, this position was anatase phase peak. The photocatalytic activity was controlled by

anatase proportion in film which was important factor in chromium(VI) removal. Xagas et al.(1999) reported that the media with higher anatase phase could enhance light absorption and pollutant adsorptions conducted to higher photocatalytic activity.

Upon photocatalytic reduction of chromium(VI), TiO₂ /chitosan film that prepared from 1.5% chitosan with 0.8% provided the highest efficiency which could remove 100% chromium(VI) in 100 mg/L initial concentration with the shortest time. Therefore 1.5% chitosan with 0.8% Ti was the best content for TiO₂ /chitosan film preparation.

Table 4.25 Values of k_{obs} from pseudo-first order equation for photocatalytic process using TiO₂ /chitosan film that prepared from 1.5%chitosan, 0.2% Ti with 20% acetic acid solution.

Initial concentrations of chromium(VI) (mg/L)	pseudo-first order		% Removal
	k_{obs} (min ⁻¹)	R^2	
50	0.0245	0.9879	100.00
100	0.0085	0.9222	80.61
150	0.0058	0.9348	67.53
200	0.0037	0.9352	52.65
250	0.0028	0.9128	43.75
300	0.0017	0.9400	40.39

Table 4.26 Values of k_{obs} from pseudo-first order equation for photocatalytic process using TiO₂/chitosan film that prepared from 1.5%chitosan, 0.4% Ti with 20% acetic acid solution.

Initial concentrations of chromium(VI) (mg/L)	pseudo-first order		% Removal
	k_{obs} (min ⁻¹)	R^2	
50	0.2012	0.9434	100.00
100	0.0183	0.9598	100.00
150	0.0073	0.9892	79.92
200	0.0040	0.9685	60.74
250	0.0032	0.961	53.05
300	0.0028	0.8621	46.30

Table 4.27 Values of k_{obs} pseudo-first order equation for photocatalytic process using TiO₂/chitosan film that prepared from 1.5 % chitosan, 0.6% Ti with 20% acetic acid solution.

Initial concentrations of chromium(VI) (mg/L)	pseudo-first order		% Removal
	k_{obs} (min ⁻¹)	R^2	
50	-	-	100.00
100	0.0237	0.9415	100.00
150	0.0103	0.9823	90.10
200	0.0058	0.9862	76.01
250	0.0041	0.9800	64.47
300	0.0033	0.9804	56.61

Table 4.28 Values of k_{obs} from pseudo-first order equation for photocatalytic process using TiO_2 /chitosan film that prepared from 1.5%chitosan, 0.8% Ti with 20% acetic acid solution.

Initial concentrations of chromium(VI) (mg/L)	pseudo-first order		% Removal
	k_{obs} (min^{-1})	R^2	
50	-	-	-
100	0.0358	0.9745	100.00
150	0.0146	0.9587	97.34
200	0.0066	0.9779	79.74
250	0.005	0.9931	71.65
300	0.0039	0.9843	63.84

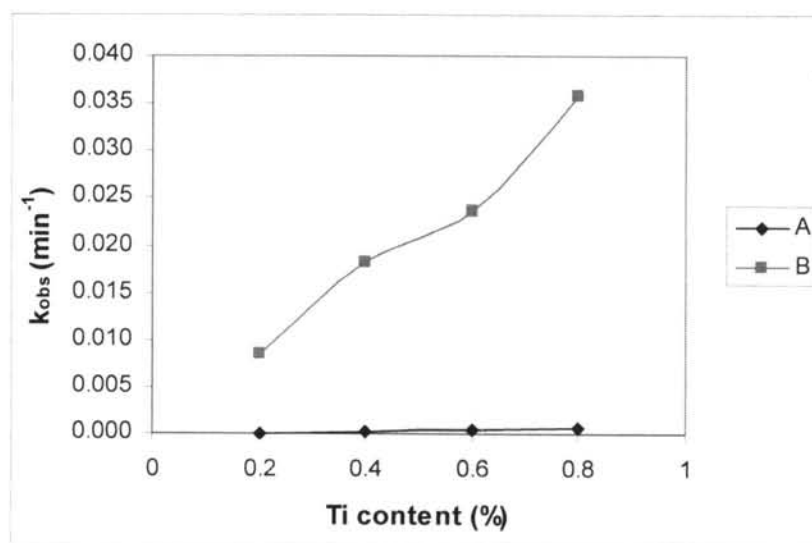


Figure 4.33 Comparison of photocatalytic decomposition rates using different Ti contents (A is TiO_2 powder and B is TiO_2 /chitosan film) in 100 mg/L chromium(VI) concentration.

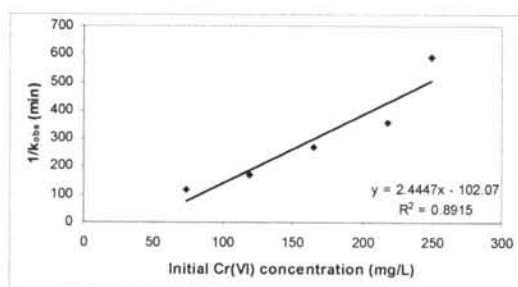
The Langmuir-Hinshelwood rate expression has been successfully used for heterogeneous photocatalytic degradation to determine the relationship between the initial degradation rate and the initial concentration of chromium (VI) (Chen et al., 1998):

$$\frac{1}{k_{obs}} = \frac{1}{k \cdot K_{cr(VI)}} + \frac{[Cr(VI)]_o}{k} \quad (\text{Eq. 4.16})$$

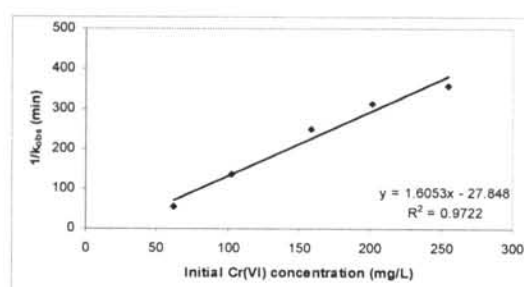
Where $[Cr(VI)]_o$ is the initial concentration of chromium (VI) in the unit of mg/L

$K_{cr(VI)}$ is the Langmuir-Hinshelwood adsorption equilibrium constant in the unit of L/mg

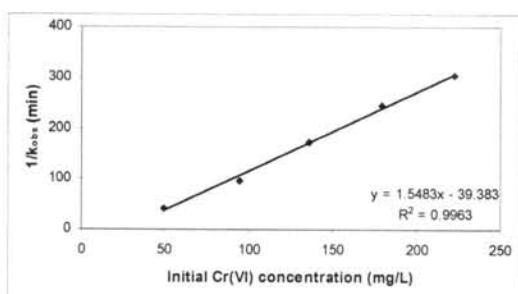
k is the rate constant of surface reaction in the unit of mg/L.min



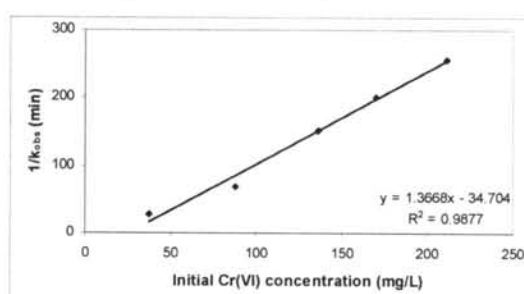
a) 1.5% chitosan, 0.2% Ti



b) 1.5% chitosan, 0.4% Ti



c) 1.5% chitosan, 0.6% Ti



d) 1.5% chitosan, 0.8% Ti

Figure 4.34 Determination of adsorption equilibrium constants and degradation rate constants chromium(VI) by using TiO₂/chitosan film that prepared from a) 1.5% chitosan, 0.2% Ti, b) 1.5% chitosan, 0.4% Ti, c) 1.5% chitosan, 0.6% Ti and d) 1.5% chitosan, 0.8% Ti

Figure 4.34 shows determination of the adsorption equilibrium constant and degradation rate constant for chromium (VI) in the range of initial concentrations 100 to 300 mg/L by plotting between $1/k_{obs}$ and initial chromium(VI) concentration. The Langmuir-Hinshelwood equations for photocatalytic process using TiO_2 /chitosan films in variation of chitosan contents were followed below equation that show in table 4.29.

Table 4.29 Langmuir-Hinshelwood equations for photocatalytic process using TiO_2 /chitosan films in variation of Ti contents

Chitosan contents (%)	Ti contents (%)	Langmuir-Hinshelwood Equations
		$\frac{1}{k_{obs}} = \frac{1}{k \cdot K_{cr(VI)}} + \frac{[Cr(VI)]_o}{k}$
1.5	0.2	$\frac{1}{k_{obs}} = \frac{1}{(0.409)(-0.024)} + \frac{[Cr(VI)]_o}{0.409}$
1.5	0.4	$\frac{1}{k_{obs}} = \frac{1}{(0.623)(-0.058)} + \frac{[Cr(VI)]_o}{0.623}$
1.5	0.6	$\frac{1}{k_{obs}} = \frac{1}{(0.646)(-0.039)} + \frac{[Cr(VI)]_o}{0.646}$
1.5	0.8	$\frac{1}{k_{obs}} = \frac{1}{(0.732)(-0.039)} + \frac{[Cr(VI)]_o}{0.732}$

4.3 The effect of photocatalytic process on mechanical properties of film

From last experiment, it was found that TiO_2 /chitosan film from 1.5% chitosan with 0.8% Ti was the best condition and provided the highest efficiency for chromium(VI) removal. Therefore in this experiment, the mechanical properties of this films after illumination at each time were investigated. The films in this study consisted of TiO_2 /chitosan film in best condition (1.5% chitosan with 0.8% Ti) and chitosan film (1.5% chitosan with 0 % Ti) which placed in 100 mg/L chromium(VI) concentrated and distilled

water for illumination. After photocatalytic process the mechanical properties of film such as its elongation at break and tensile strength were observed.

In term of mechanical properties, tensile strength value of chitosan film (1.5% chitosan with 0 % Ti) and TiO₂/chitosan film(1.5% chitosan with 0.8% Ti) at time zero or after placed two types of film in distilled water under non-irradiation about 30 min were 4.127 N/mm² and 0.914 N/mm², respectively. While the elongation at break of chitosan film and TiO₂/chitosan film were 61.35% and 46.63%, respectively.

When compared between TiO₂/chitosan and chitosan films at time zero, the result shown that tensile strength and elongation at break of TiO₂/chitosan film lower than those chitosan film (Figure 4.35 and 4.36). The reason might due to TiO₂ particles that mixed into the film which reduce interaction between film molecule. After UV illuminated, tensile strength and elongation at break of two types of film were investigated and it was found that tensile strength and elongation at break of TiO₂/chitosan film. In addition, chitosan films in distilled water tended to decrease when increased illumination time because UV radiation might destroy chitosan structure. For TiO₂/chitosan and chitosan films in 100 mg/L chromium(VI), those tensile strength and elongation at break tended to decreased when increased illumination time. The explanation might come from the fact that UV radiation can destroy chitosan polymer structure. In addition, at acidic condition chitosan which protonated amino group (-NH₃⁺) as a functional of chitosan biopolymer might capture negatively charged (chromium(VI) existed as HCrO₄⁻) causing the destroying intramolecular hydrogen bonding of chitosan polymer.

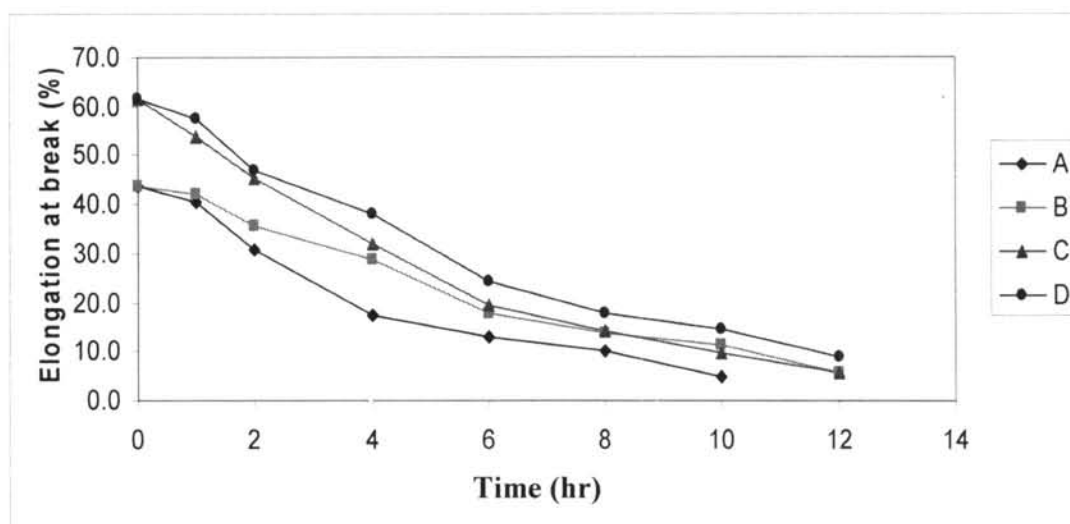


Figure 4.35 Relationship between elongation at break(%) of film and UV illumination time(hr) (A is TiO_2 /chitosan film in 100 mg/L chromium(VI), B is TiO_2 /chitosan film in distilled water, C is chitosan film in 100 mg/L chromium and D is chitosan film in distilled water)

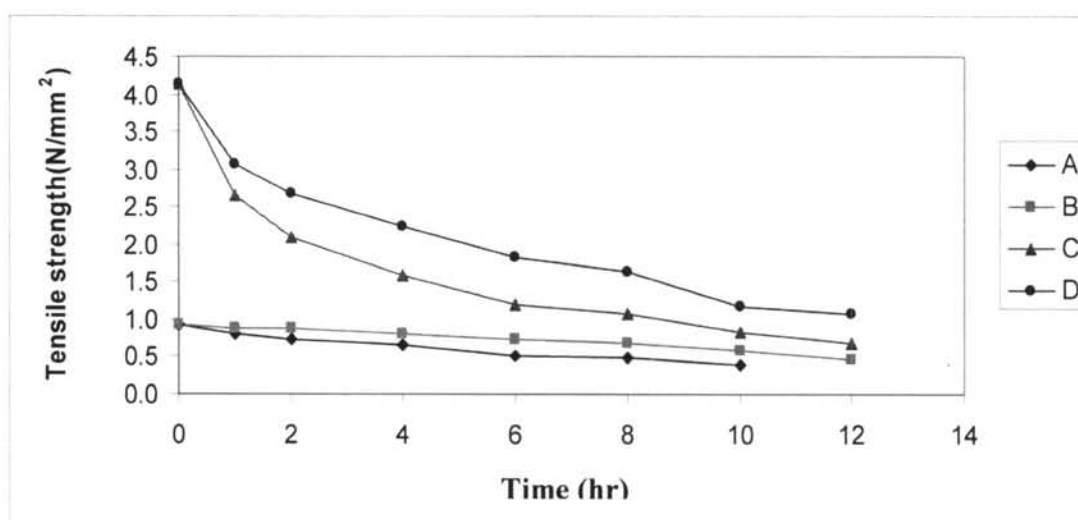


Figure 4.36 Relationship between tensile strength(N/mm^2) of film and UV illumination time(hr) (A is TiO_2 /chitosan film in 100 mg/L chromium(VI), B is TiO_2 /chitosan film in distilled water, C is chitosan film in 100 mg/L chromium and D is chitosan film in distilled water)